

# *SIPMs: Italy Team Report*



SiPMs development at FBK-irst started in 2005 as collaboration with INFN(\*) for:

- tracking with sci-fi;
- PET;
- TOF;
- calorimetry;
- muon counters.

(\*) Pisa, Bari, Bologna, Messina, Perugia, Roma, Trento, Trieste, Udine



*Aldo Penzo, INFN-Trieste*  
*HCAL Working group, CMS Upgrade Workshop*  
*FNAL, 19 Nov 2008*

# Summary of multiple contributions

- [http://www.ts.infn.it/eventi/TPDPPC\\_2008/](http://www.ts.infn.it/eventi/TPDPPC_2008/)
- Valter Bonvicini - The INFN R&D FACTOR
- Claudio Piemonte - Development of SiPMs at FBK-irst
- Arjan Heering - Requirements of SiPMs for CMS HCAL upgrades
- Adam Para - Photodectors for dual readout calorimetry: characterization and testing of SiPMT's
- Aldo Penzo - Calorimetry R&D in FACTOR
- Dalla Torre - Single photon detectors for Cherenkov Imaging
- Valter Bonvicini - Preliminary results on SiPM irradiation tests
- Giovanni Pauletta - SiPM characterization and applications; past and future test activities at FNAL

# ***FACTOR Project***

**[Walter Bonvicini *et al.*: Messina, Roma, Trieste, Udine + FBK/irst]**

- Within FBK/irst - INFN agreement, a (3-year) project (FACTOR) aims at establishing SiPMs as choice devices for (dual) readout of (compensating) hadron calorimeters.
- FBK-IRST has long-standing collaboration with INFN in the fields of:
  - Radiation-hard Si detectors (for SLHC)
  - use of oxygen-rich substrates:
    - DOFZ substrates
    - Cz/MCz substrates (Magnetic Czochralski)
    - Epitaxial substrates
  - use of p-type substrates
  - Integration of Si detectors and (front-end) circuits on the same substrate
  - 3D detectors

# ***ITC-IRST (Trento)***

ITC (Now Fondazione Bruno Kessler ) – IRST is a public research and technology Institute, working since 1994 on the development and on the production of semiconductor devices for research and applications. It has a fully equipped Microfabrication Laboratory in which silicon devices are built.

- Ion Implanter
- Furnaces
- Litho (Mask Aligner )
- Dry&Wet Etching
- Sputtering &Evaporator
- On line inspection
- Dicing



# Activity of SRD group

Development and production of Si radiation detectors.

Expertise covers the main aspects of the development:

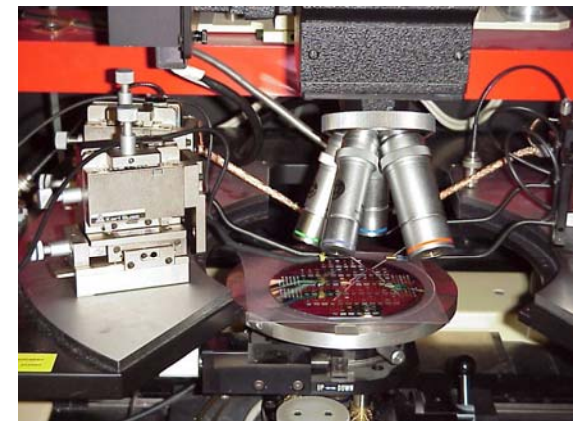
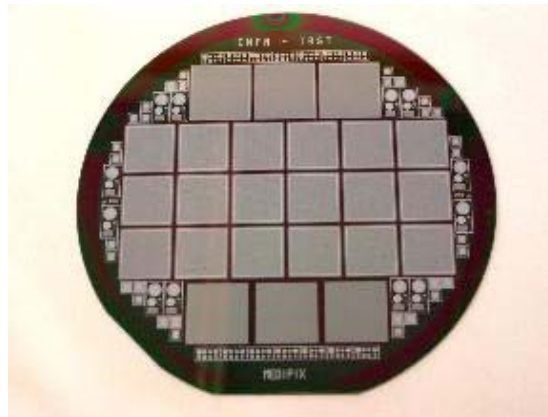
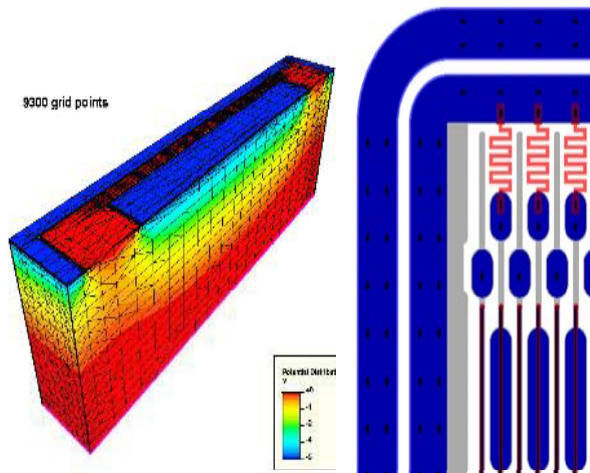
TCAD simulation  
CAD design



Fabrication



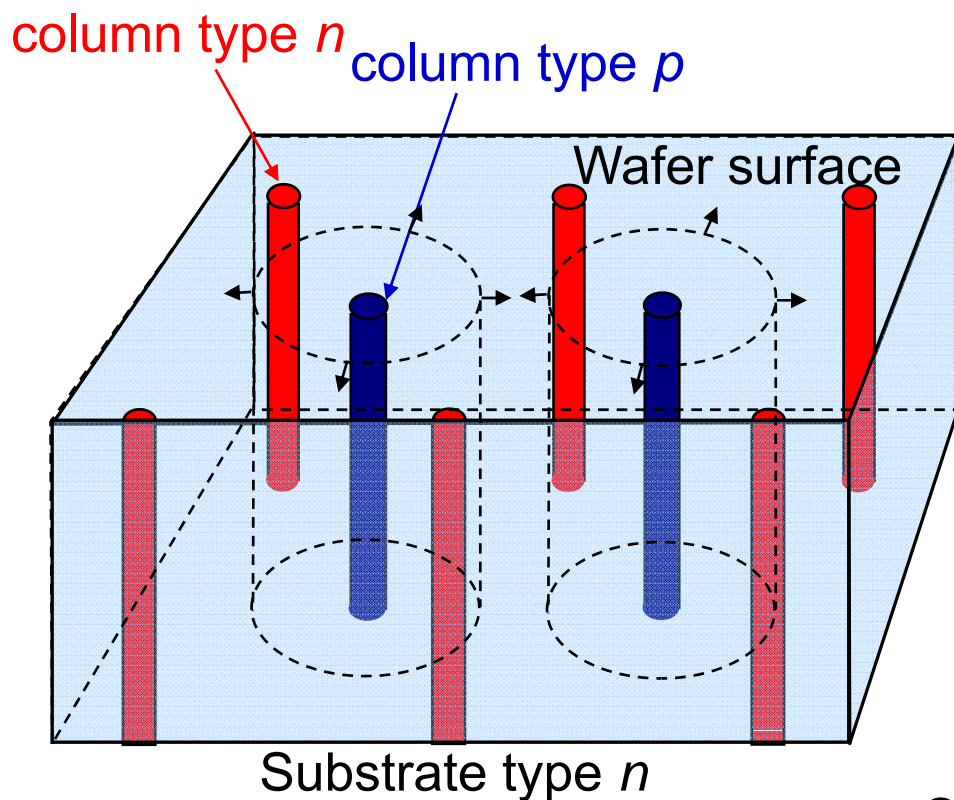
Device testing



## *Previous/current products*

- **Double-sided strip detectors:**
  - Area: 7.5x4.2cm<sup>2</sup>
  - Orthogonal or inclined strips on 2 sides
  - DC- or AC-coupled
  - 700 + 800 “in spec” devices fabricated for AMS and ALICE (2002-2005)
- **Pixel detectors:**
  - MEDIPIX (thick 1.5mm), 170x170/55x55 μm<sup>2</sup>
  - ALICE (200μm) 400x50 μm<sup>2</sup>

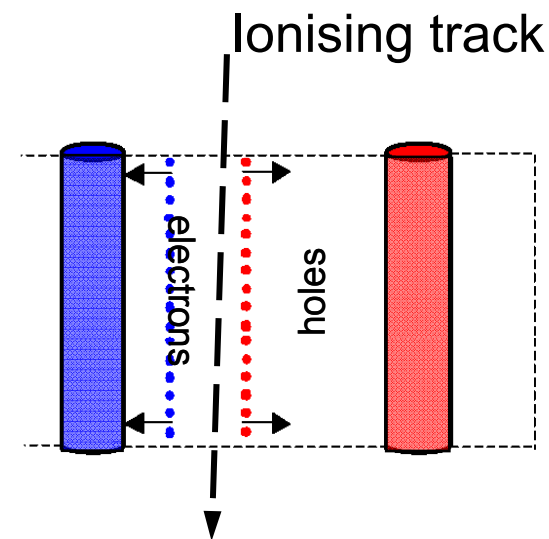
# 3D Si Detectors



Electrodes are columns penetrating into the bulk



extremely **fast** and **radiation resistant**



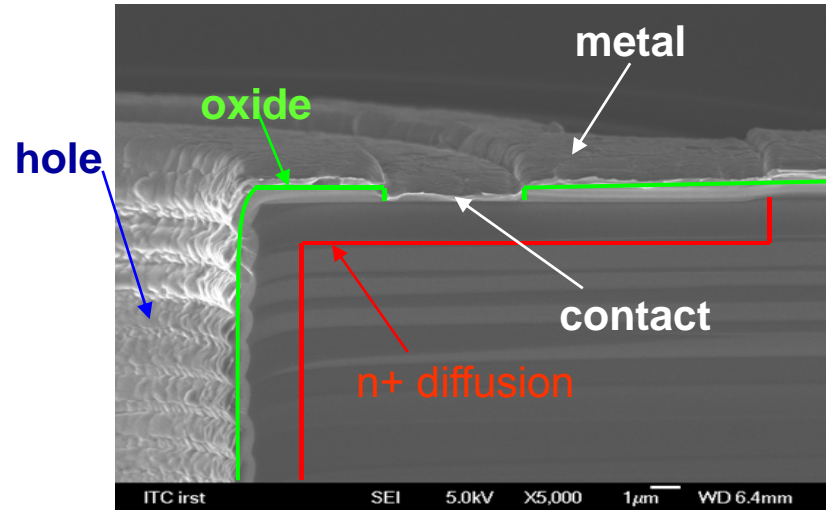
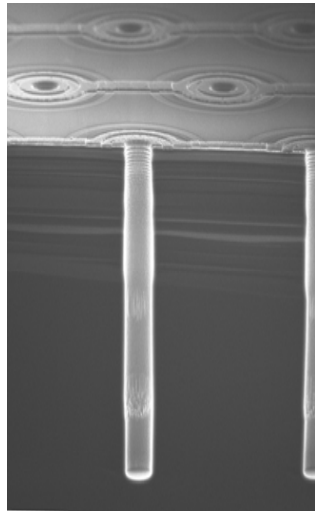
(carriers generated along the track are collected almost simultaneously)

Short distance electrodes  $n$  e  $p$ :  
⇒ low depletion voltage  
⇒ short charge collection distance

See S. Parker et al., NIM A395 (1997)

# 3D Si Detector Project

FBK-irst and INFN-Trieste (L. Bosisio *et al.*)



**SEM pictures  
of 3D devices**

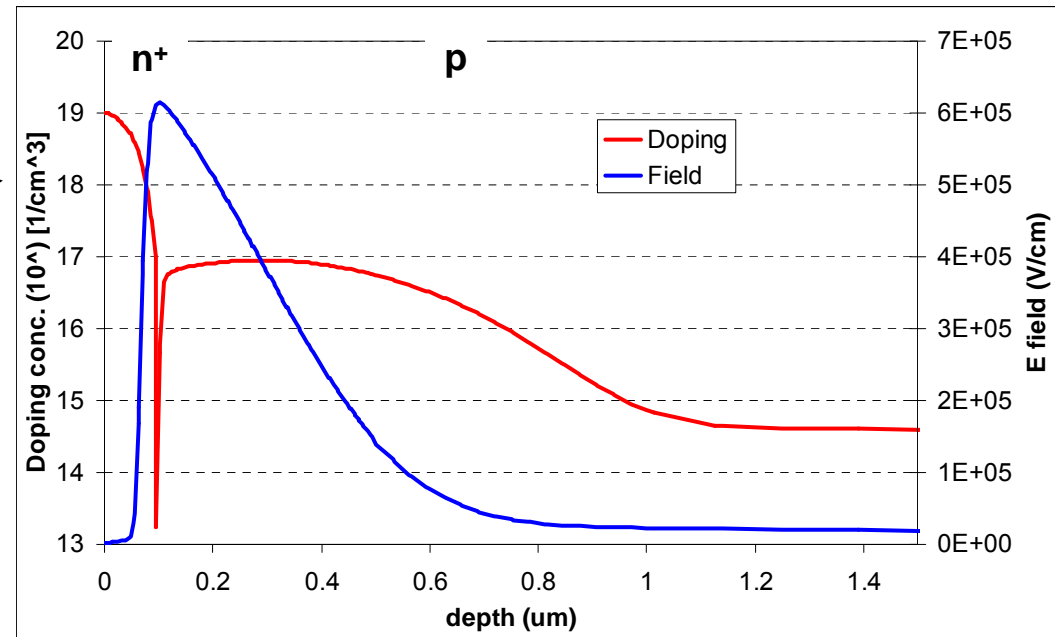
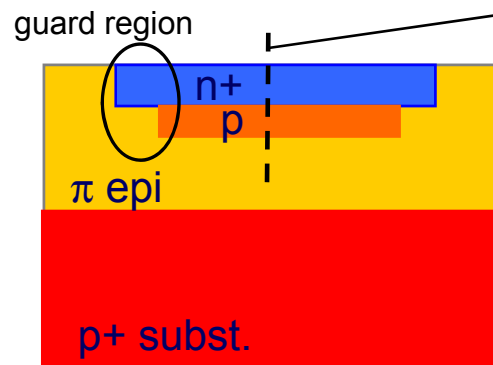
**Col. depth 180µm  
Col. width 10µm**

- Collaboration for tests:
  - Ljubljana
  - UC Santa Cruz
  - INFN-Genova (ATLAS Pixel)
  - CERN (ALICE Pixel)
- **Applications of this technology in other devices:**
  - ‘throughout holes’ transfer signals to back face (ex. SiPM)
  - planar detectors with ‘active edge’ (ex. imaging X-rays)



# SiPM IRST technology

## Shallow-Junction SiPM

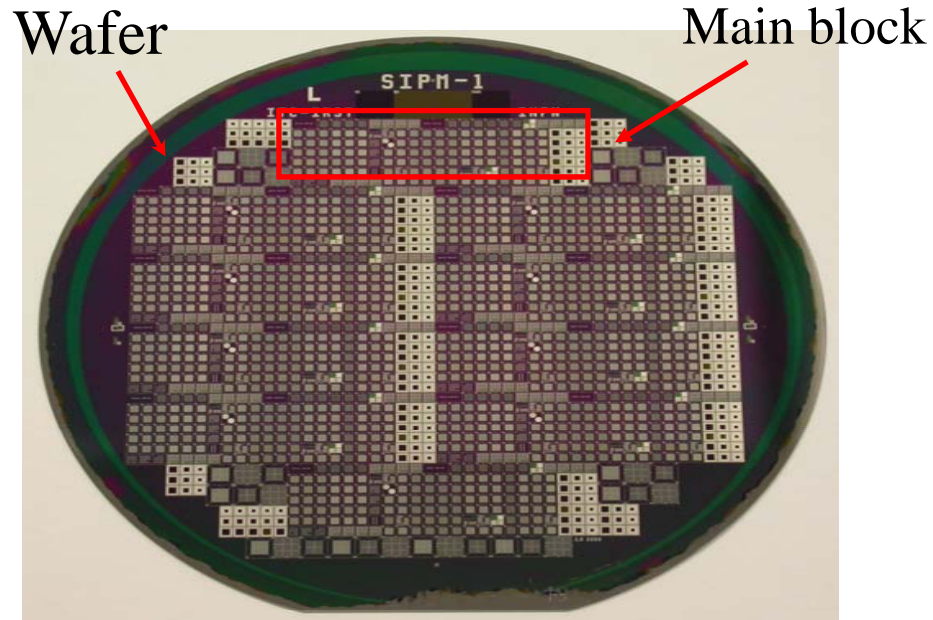


High field region | Drift region

- Substrate: p-type epitaxial
- 2) Very thin n+ layer
- 3) Polysilicon quenching resistance
- 4) Anti-reflective coating optimized for  $\lambda \sim 420\text{nm}$

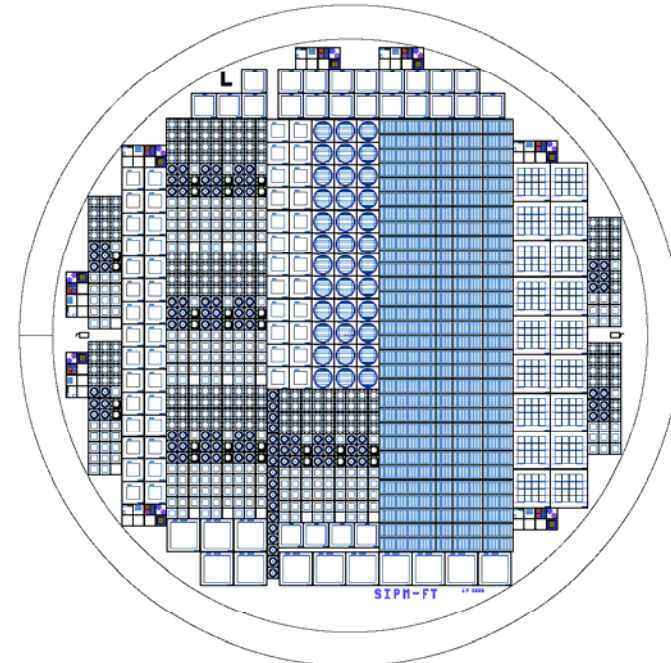
[C. Piemonte:  
“A new Silicon Photomultiplier  
structure for blue light detection”  
NIMA 568 (2006) 224-232]

# Configuration on Si wafer



First production run (2005)

Second production run



- square SiPMs with area:
  - $1 \times 1 \text{mm}^2$ ,  $2 \times 2 \text{mm}^2$
  - $3 \times 3 \text{mm}^2$ ,  $4 \times 4 \text{mm}^2$
- circular SiPMs
- linear arrays of SiPMs:
  - $1 \times 8$ ,  $1 \times 16$ ,  $1 \times 32$
- $4 \times 4$  matrix of SiPMs

# Characteristics of FBK-irst SiPMs

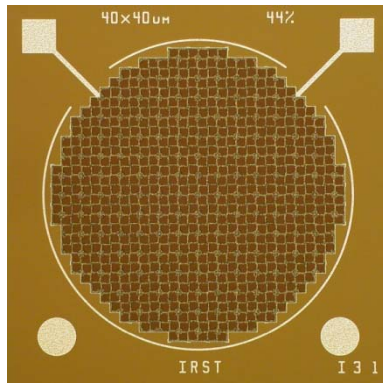
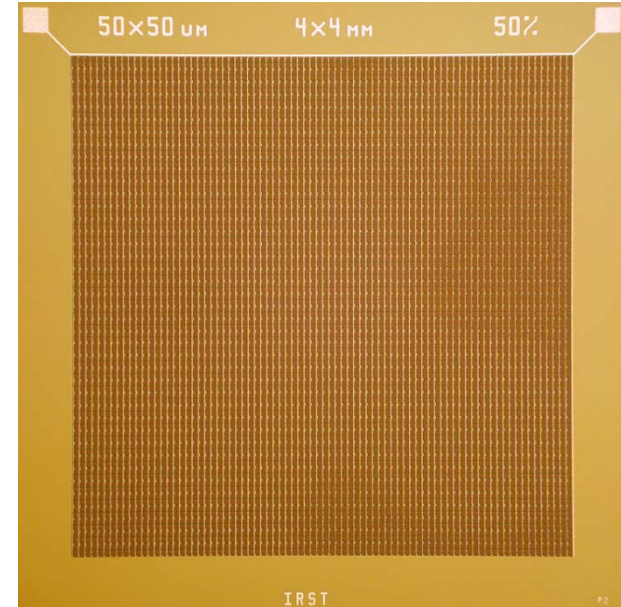
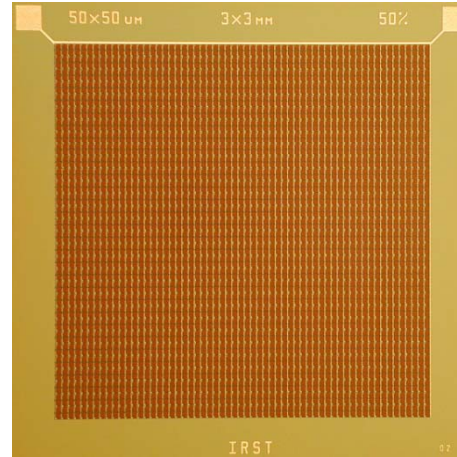
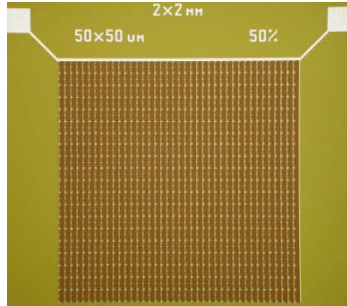
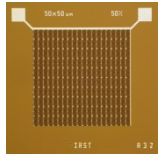
## Geometries:

1x1mm<sup>2</sup>

2x2mm<sup>2</sup>

3x3mm<sup>2</sup> (3600 cells)

4x4mm<sup>2</sup> (6400 cells)



Circular: diameter 1.2mm  
diameter 2.8mm

**Fill factor:** 40x40μm<sup>2</sup> => ~ 40%

50x50μm<sup>2</sup> => ~ 50%

100x100μm<sup>2</sup> => ~ 76%

# *Tests performed at FBK*

- *I-V measurement*

- fast test to verify functionality and uniformity of the properties



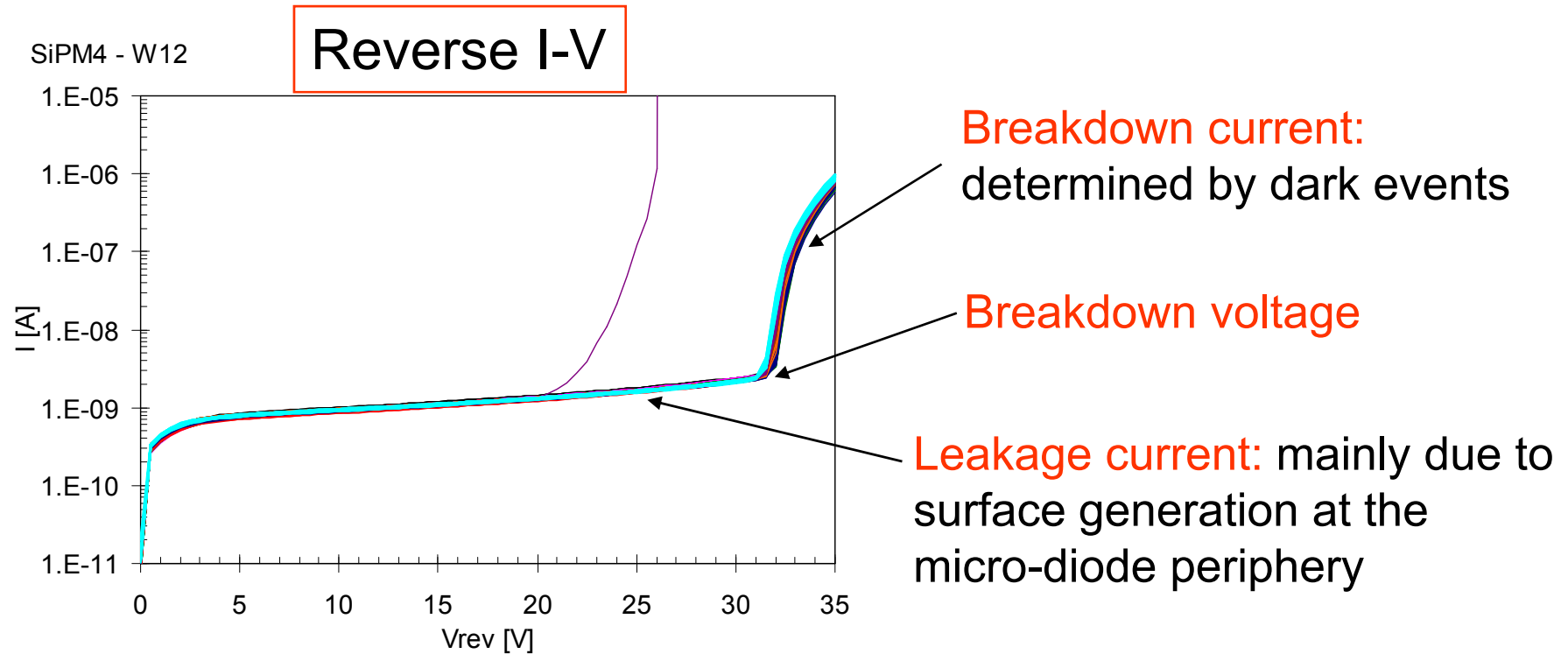
C. Piemonte et al.  
“Characterization of the first prototypes  
of SiPM fabricated at ITC-irst”  
IEEE TNS, February 2007

- *Functional characterization in dark*

- for a complete characterization of the output signal and noise properties (signal shape, gain, dark count, optical cross-talk, after-pulse)

- *Photo-detection efficiency*

# Static characteristic (I-V)



Very useful fast test. Gives info about:

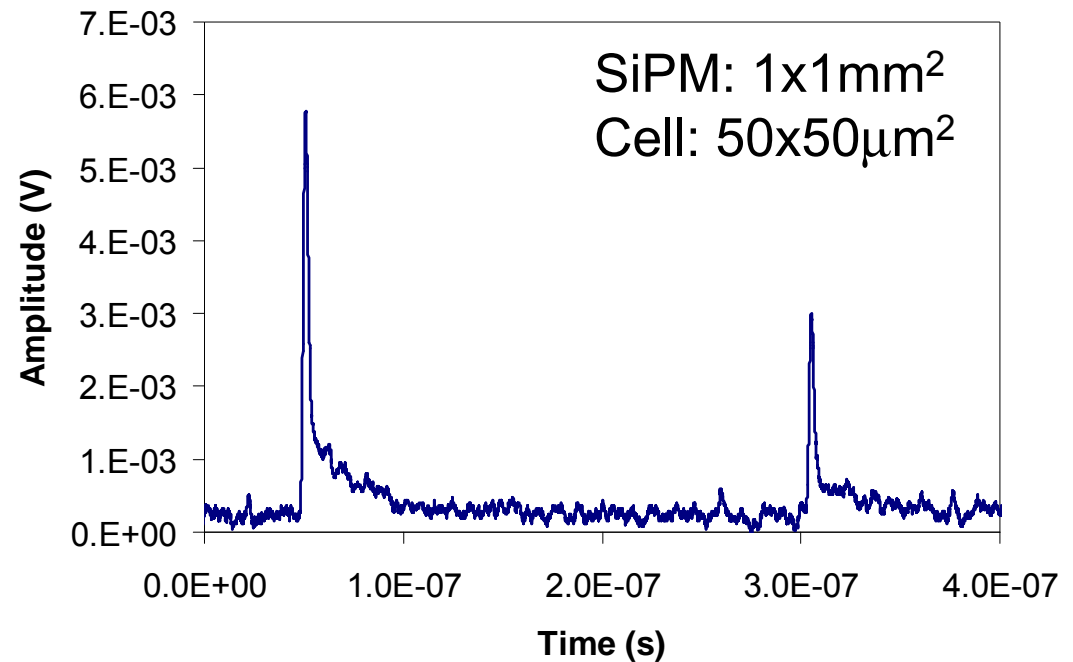
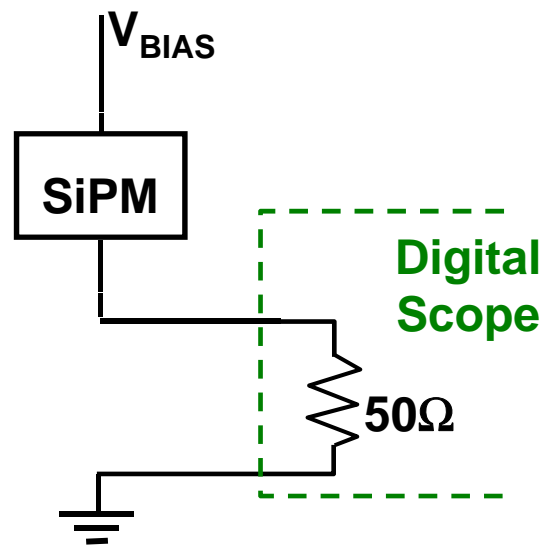
- Device functionality
- Breakdown voltage
- (Dark rate)x(Gain) uniformity
- Quenching resistance (from forward I-V)

**Performed on  
several thousands of  
devices at wafer level**

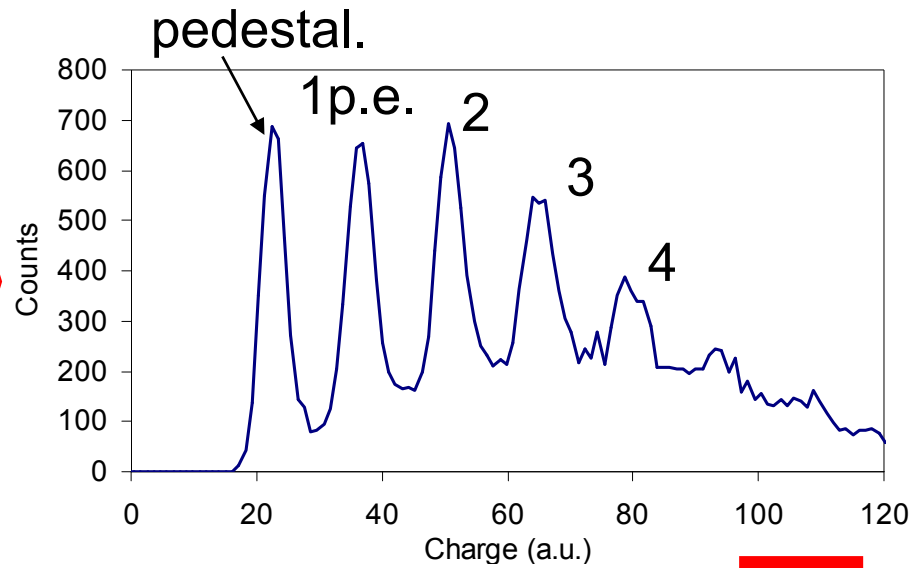
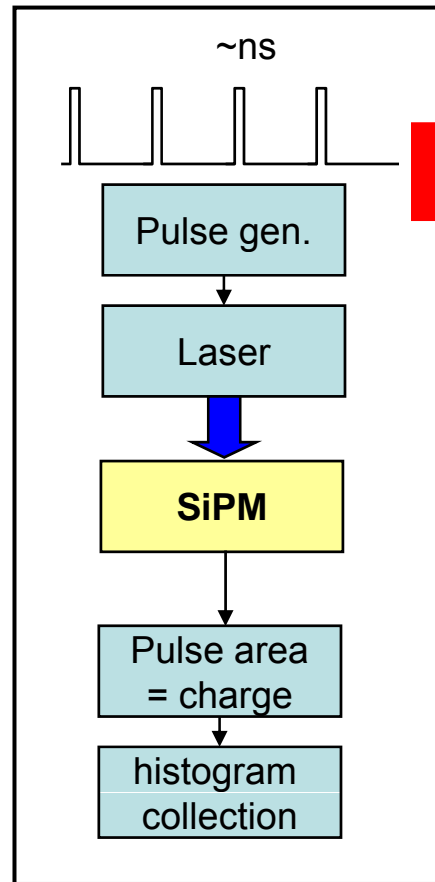
## Signal properties – NO amplifier

Dark signals are exactly equal to photo-generated signals  
→ functional measurements in dark give a complete picture of the SiPM functioning

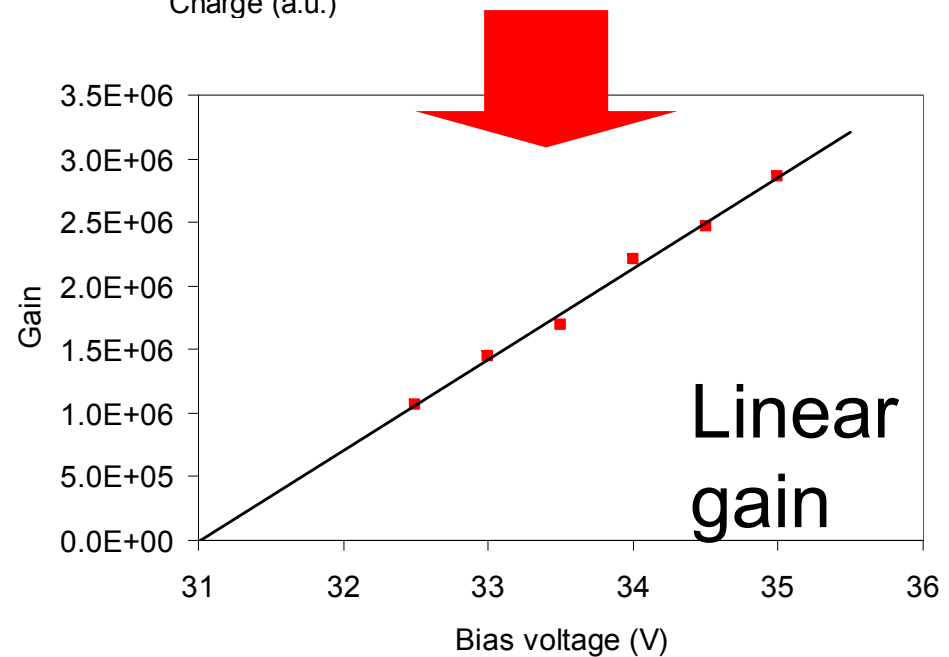
Thanks to the large gain it is possible to connect the SiPM directly to the scope



# Signal properties – NO amplifier



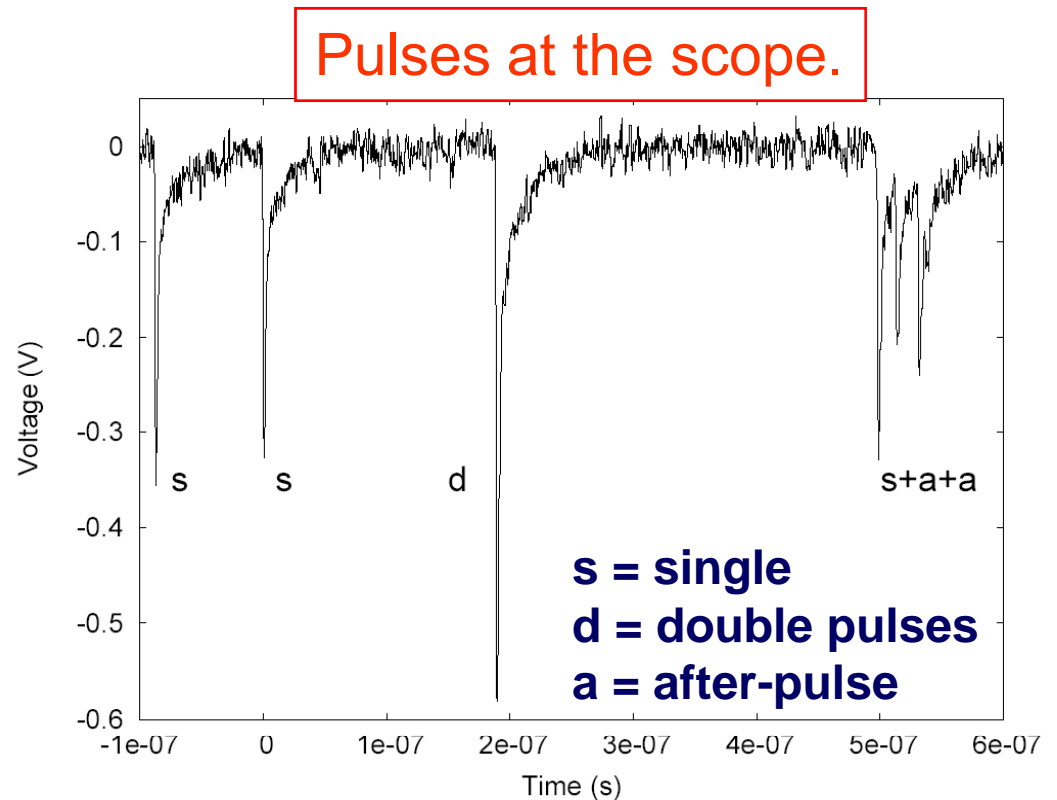
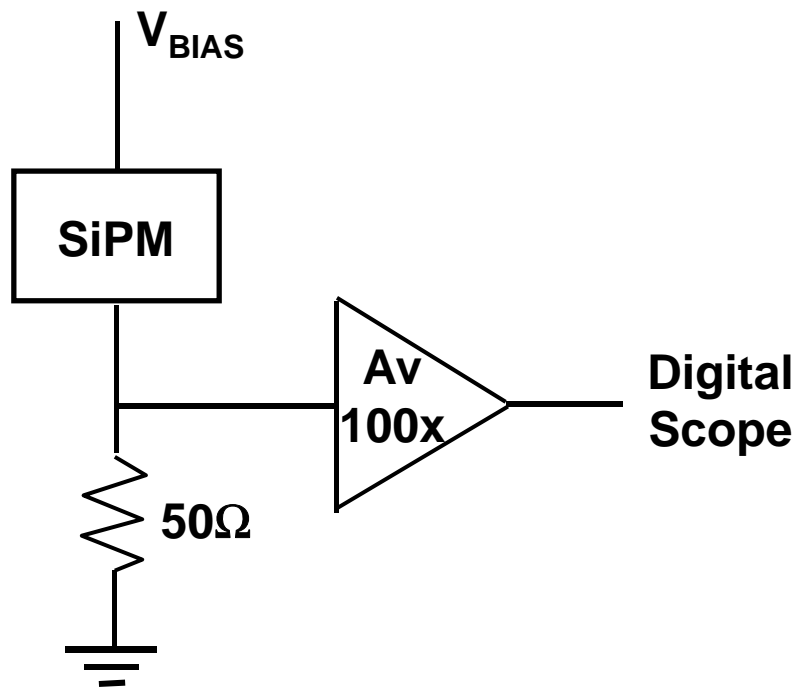
Excellent cell uniformity



Linear gain

# Signal properties – with amplifier

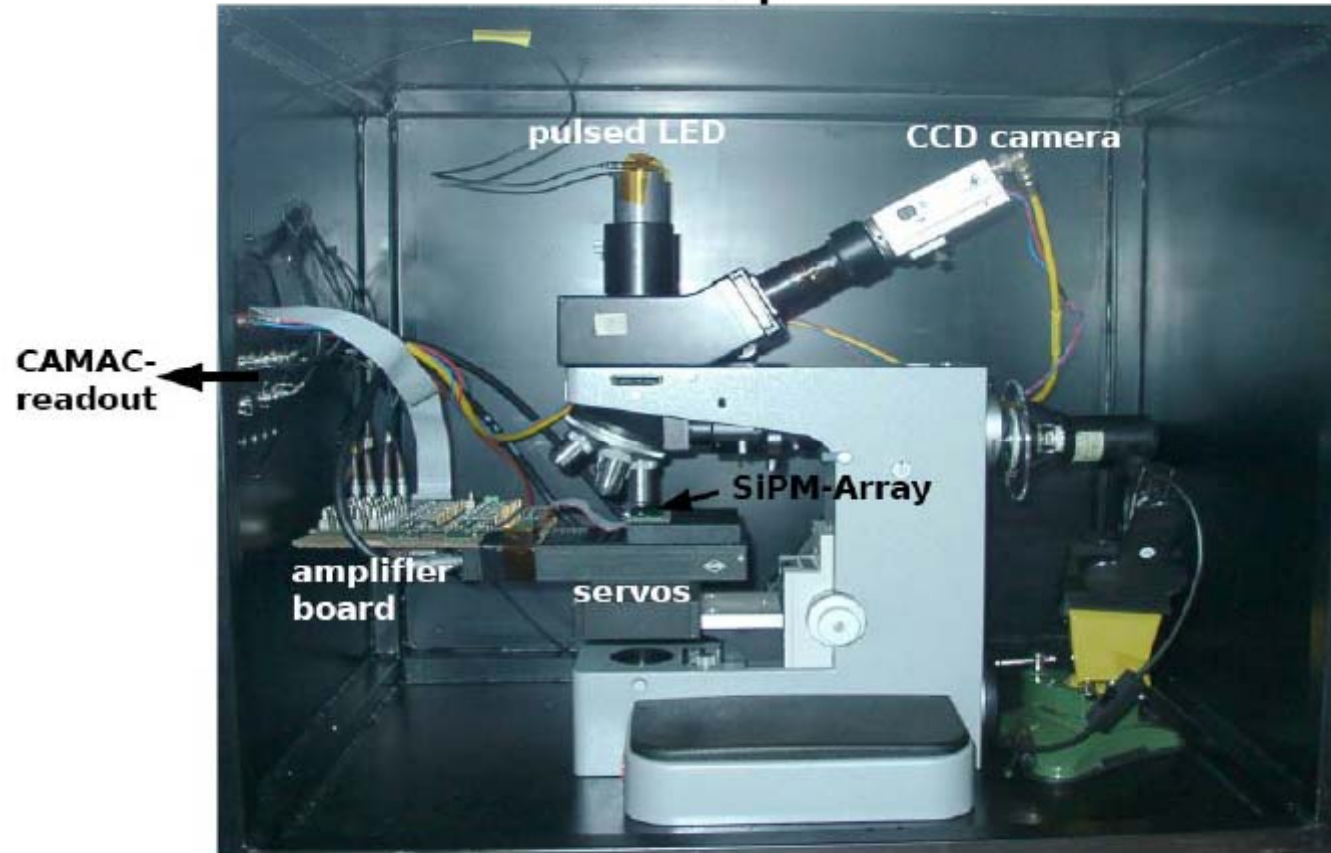
A voltage amplifier allows an easier characterization, but attention must be paid when determining the gain





# *Microcell functionality measurements*

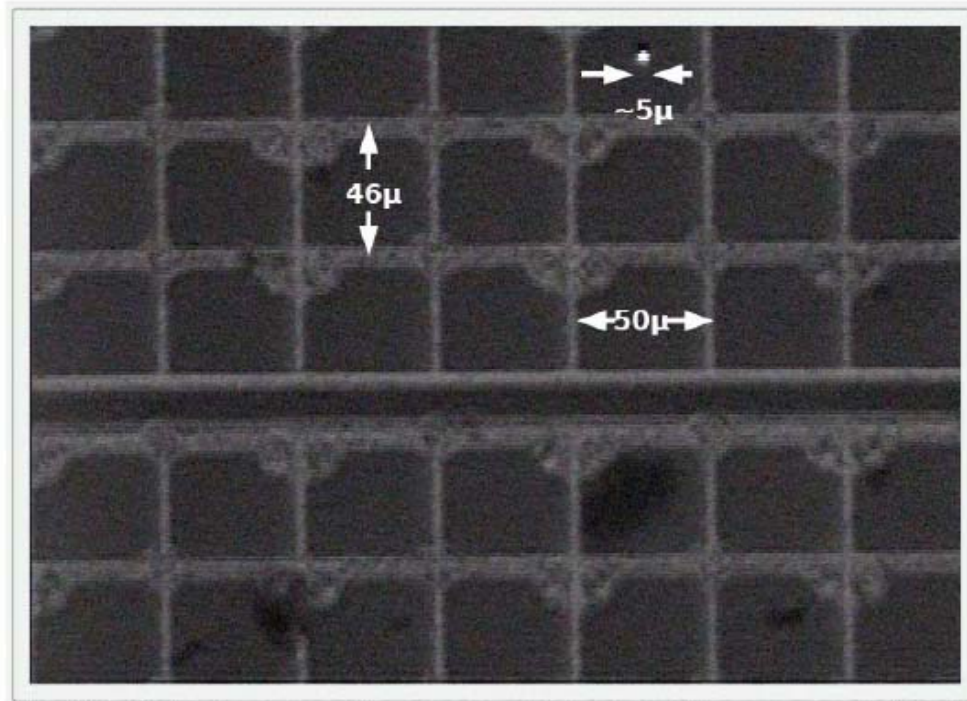
setup



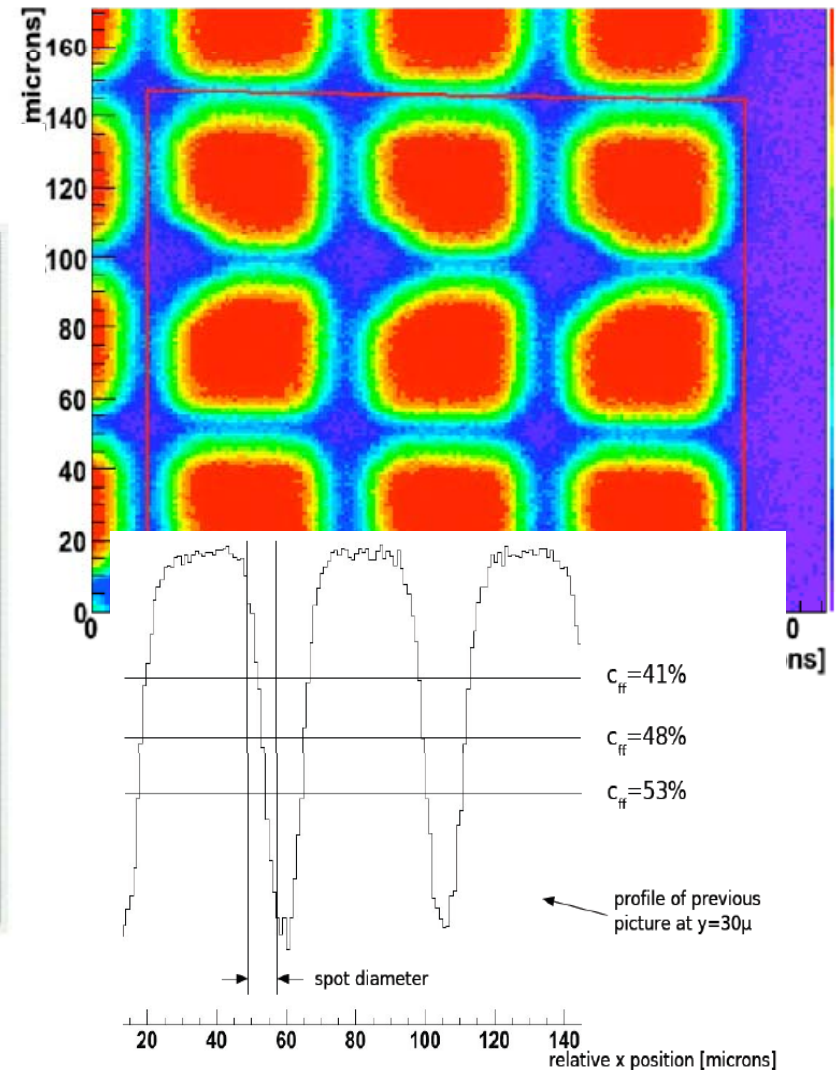
measurements with RWTH, Aachen and Josef Stefan , Ljubljana

# Pencil LED scan

Measurement of the microcells with 5 $\mu$ m LED spot diameter

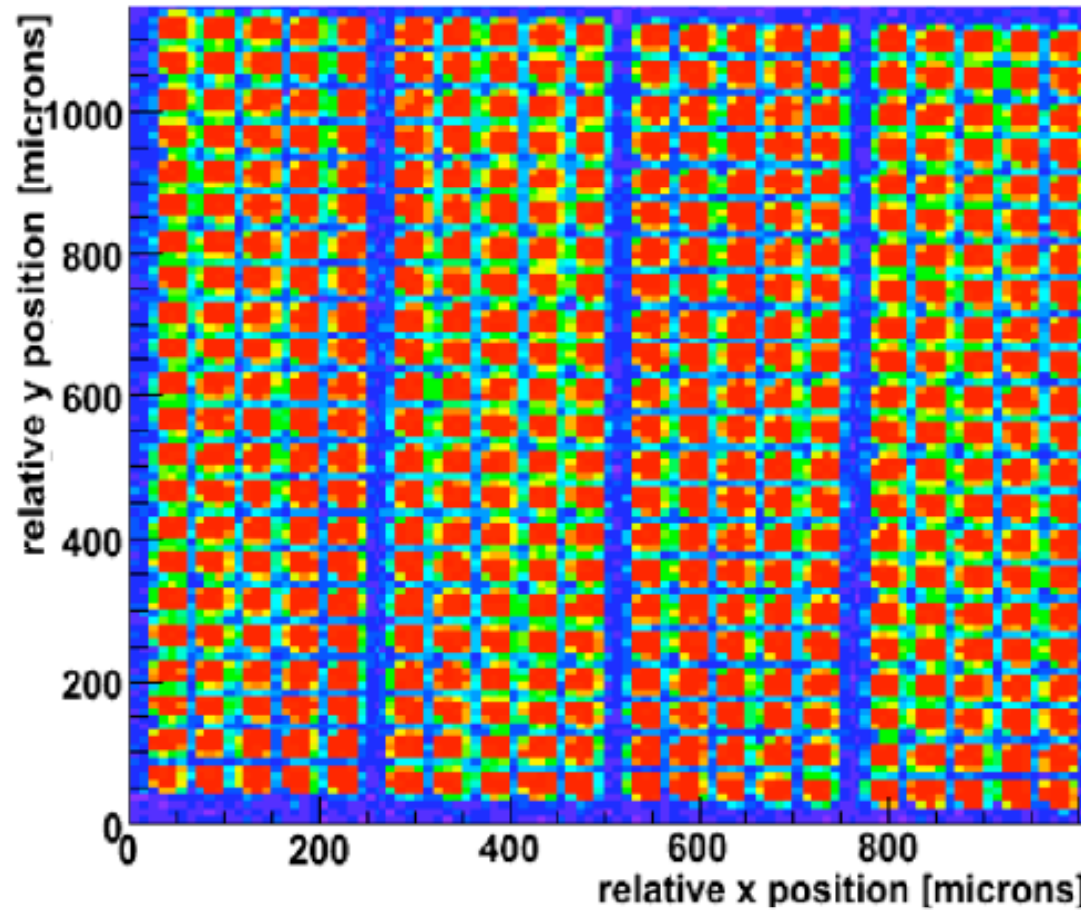


fillfactor



# *Uniformity map*

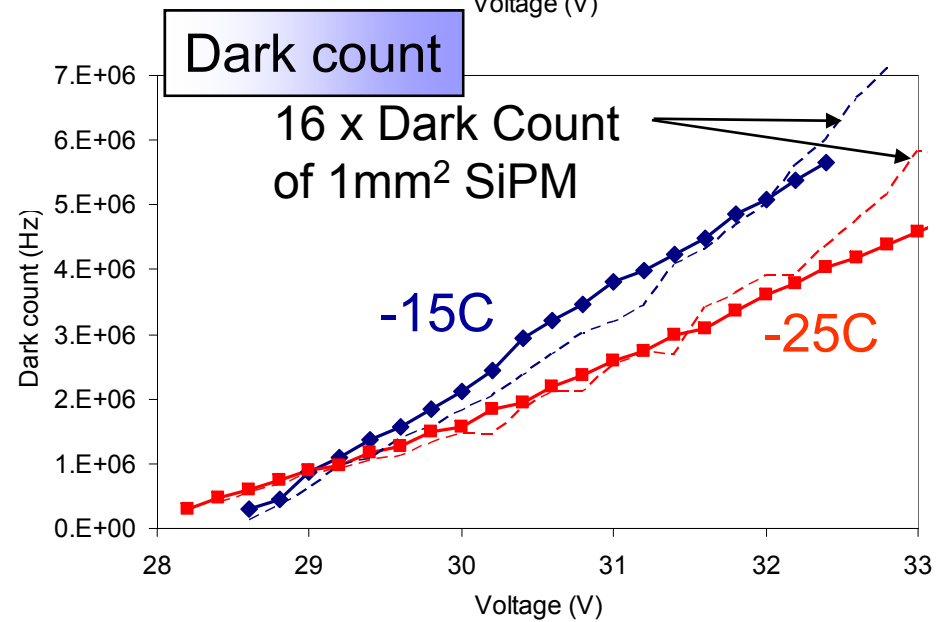
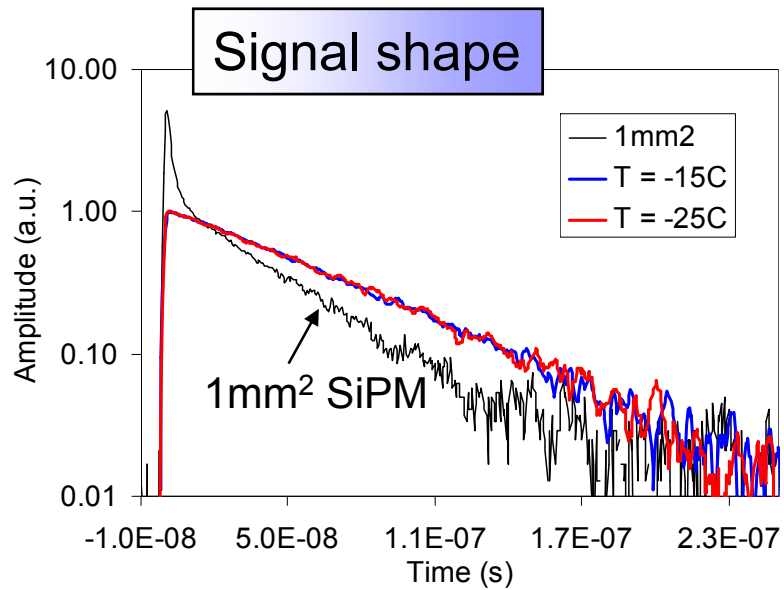
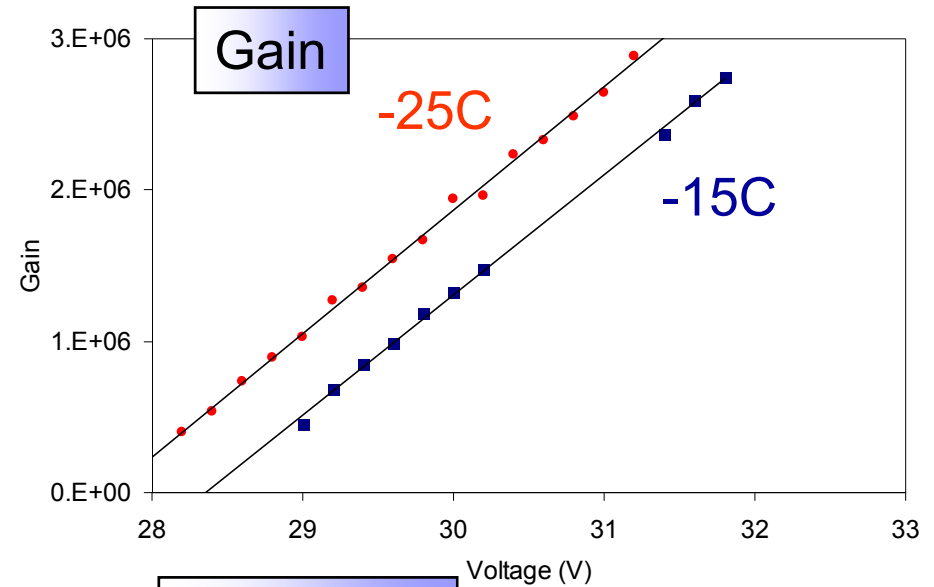
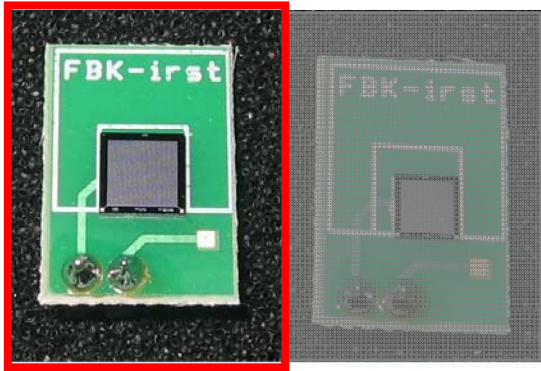
pixel quality check



step size  $10\mu$ , spot diameter  $\sim 10\mu$   $\rightarrow$  all pixels on C15 work fine

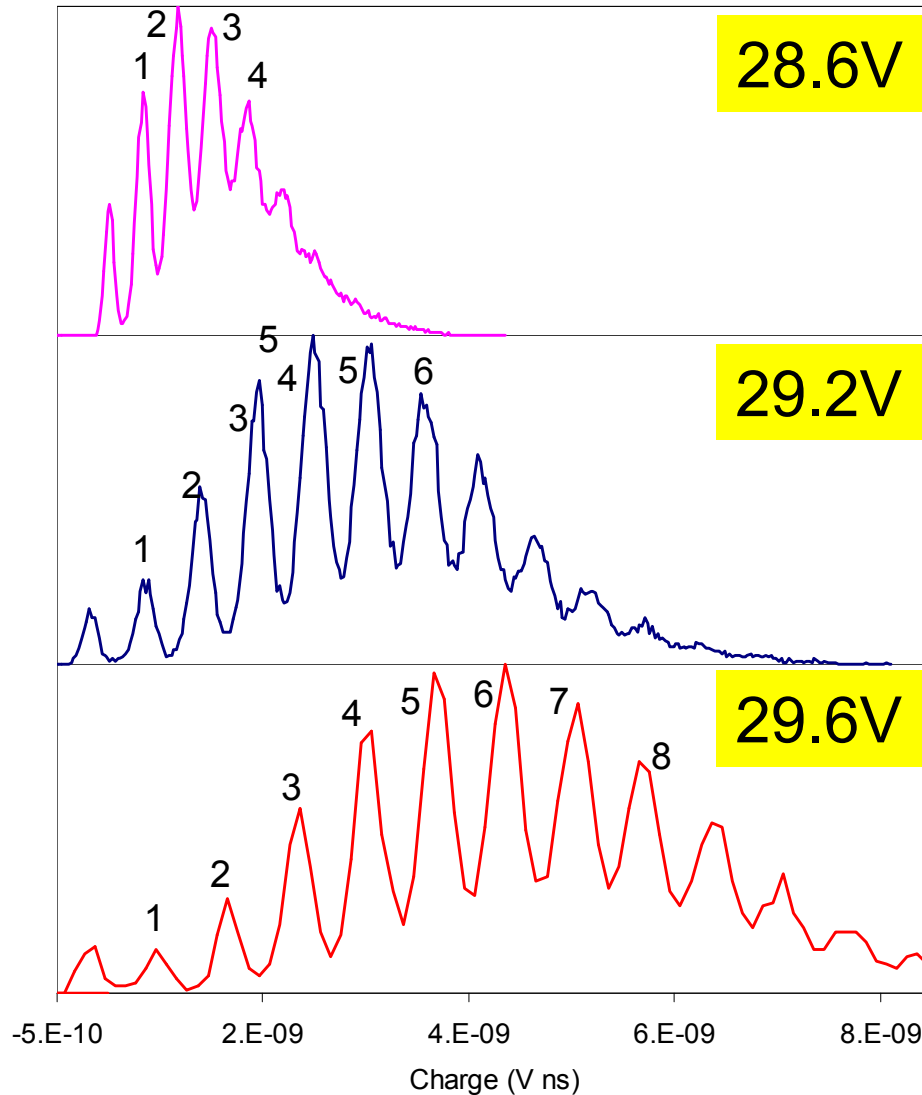
# 4x4mm<sup>2</sup> SiPM - 50x50μm<sup>2</sup> cell

4x4mm<sup>2</sup>



# 4x4mm<sup>2</sup> SiPM - 50x50μm<sup>2</sup> cell

T=-25C Vbd=27.6V



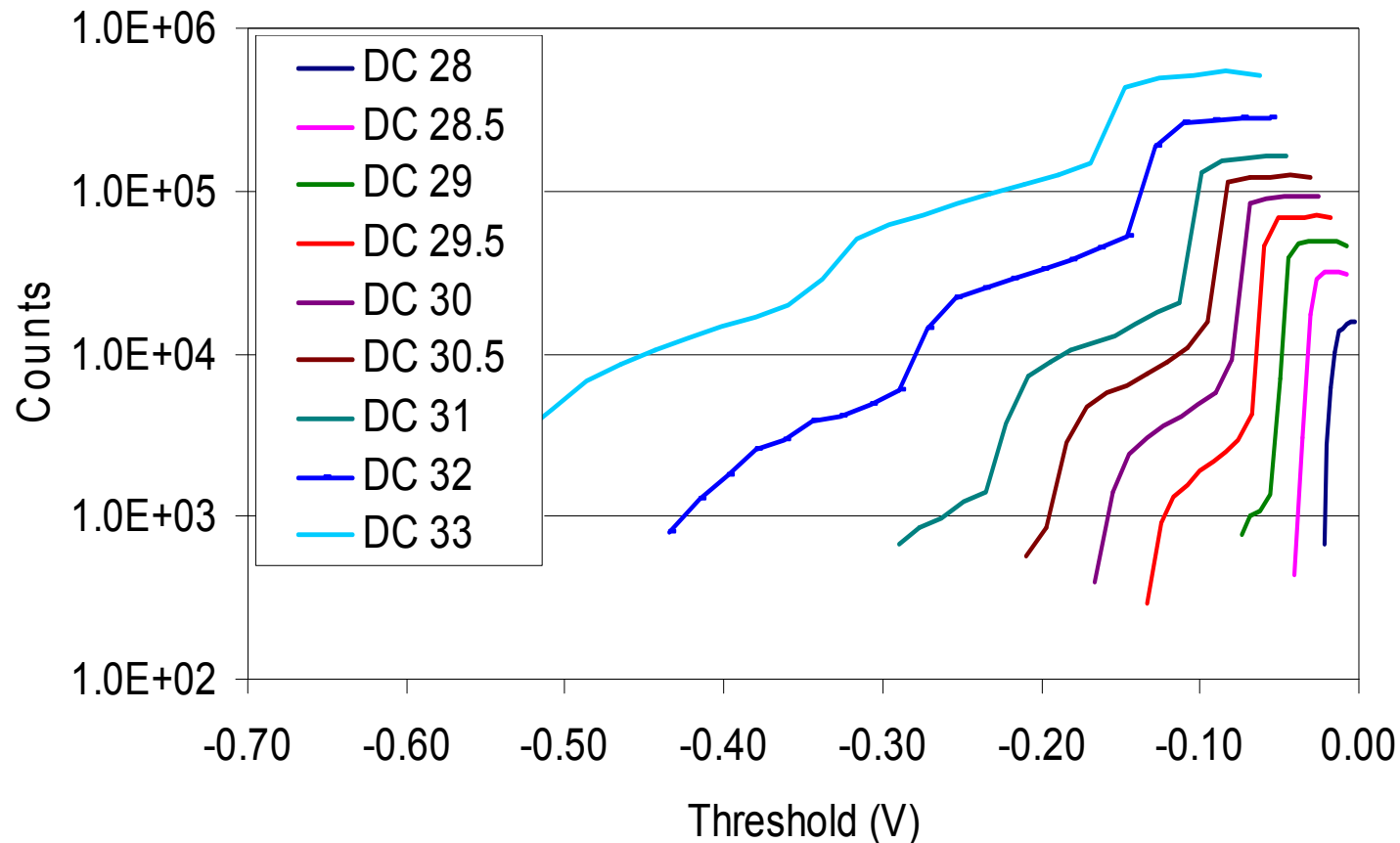
Charge spectra when illuminating the device with short light pulses

Same conclusions as for the previous device:

- Excellent cell response uniformity over the entire device (6400 cells)

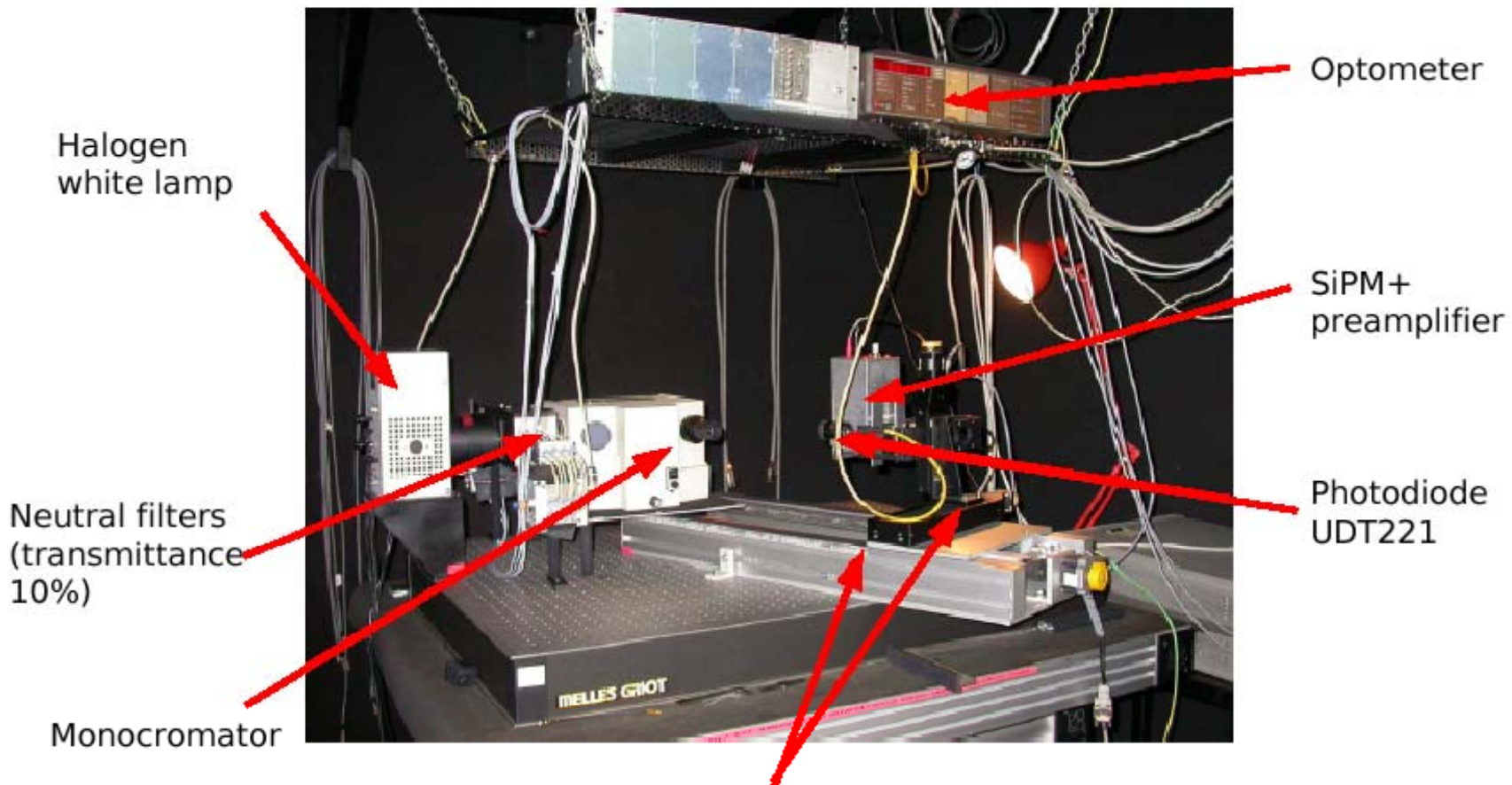
Width of peaks dominated by electronic noise

# *Dark counts vs discrim. threshold*

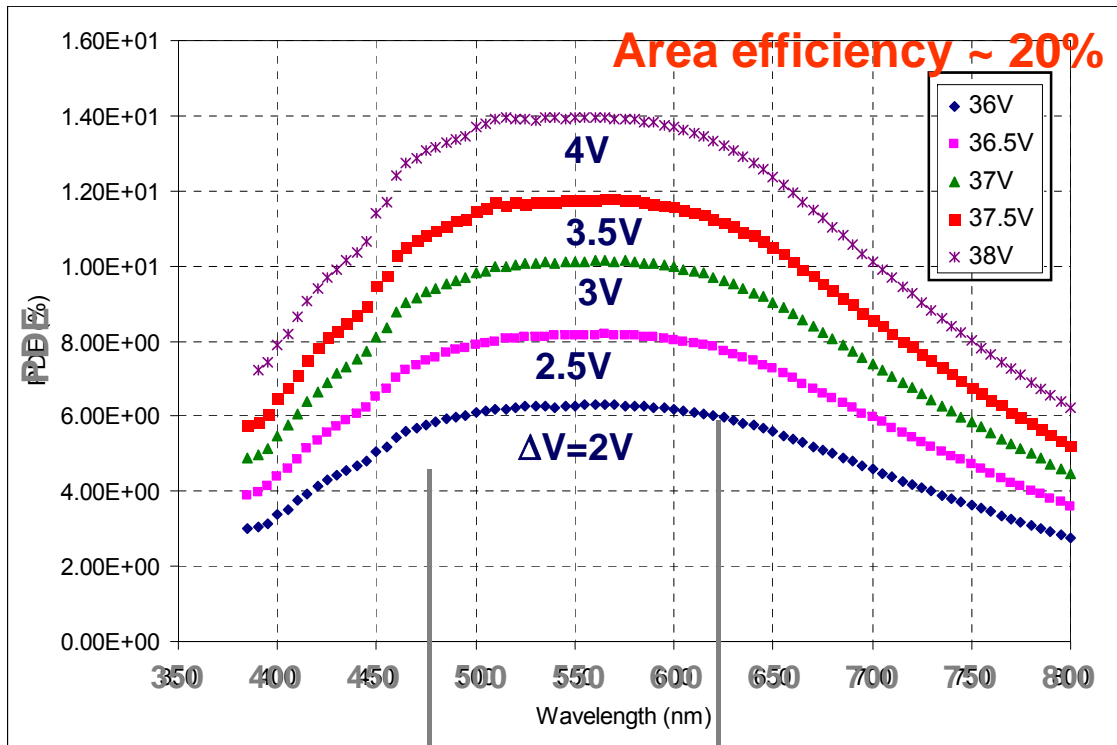


- Each of the above curves represents the dark count rate as a function of the counting discriminator threshold.
- Different curves correspond to different bias voltages. Dark counts were also measured as a function of temperature.

# *Photo-detection efficiency*



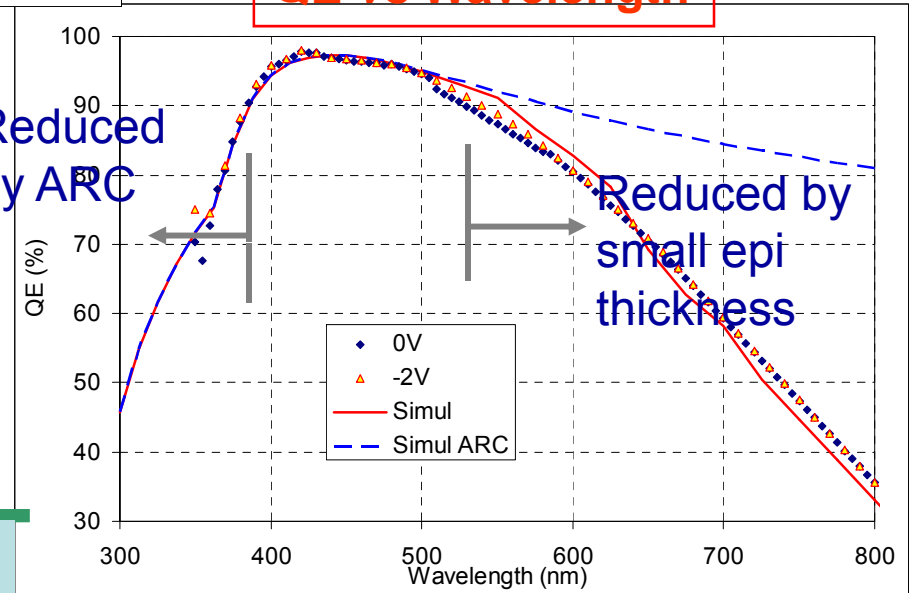
Stage with 3D micrometers movement (50um precision)



$$PDE = QE * P_t * A_e$$

QE=quantum eff.  
 $P_t$ =avalanche prob.  
 $A_e$ =area eff.

QE vs Wavelength



short  $\lambda$ :  
 low PDE  
 because  
 avalanche  
 triggered by  
 holes

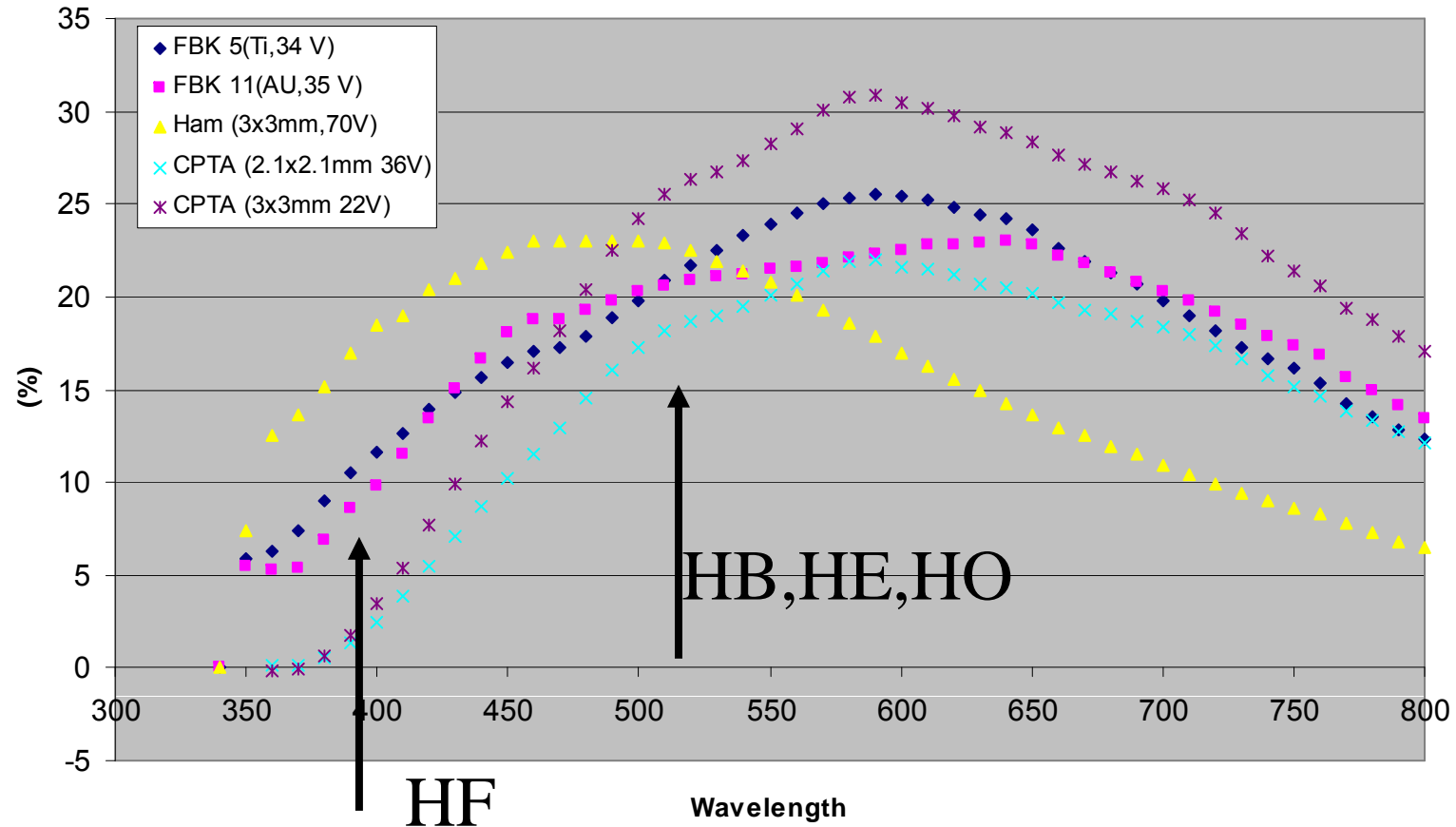
long  $\lambda$ :  
 low PDE  
 because  
 low QE

Measured on a diode



# Comparison of PDE

PDE at ~3 volt overvoltage



- From Arjan in Trieste, 3 June 2008

# Activities at Trieste-Udine

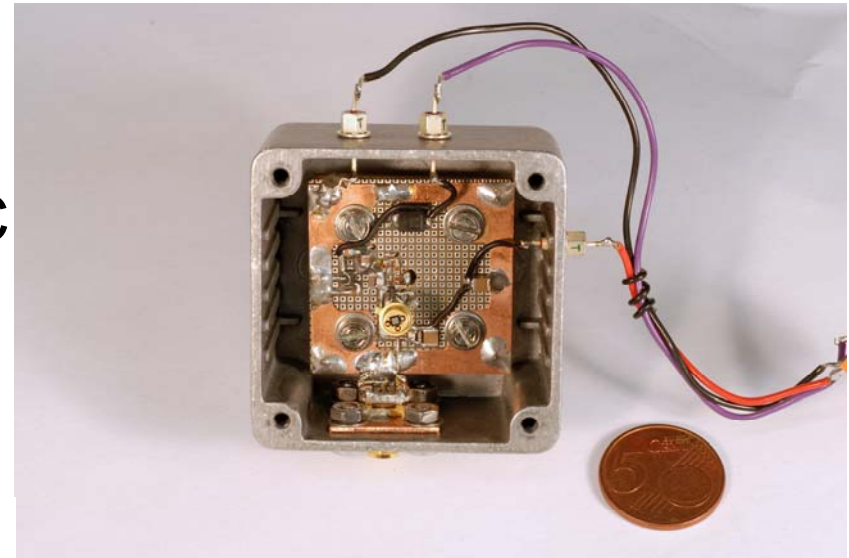
- The FACTOR collaboration is interested in the development of the device and in its optimization for application to:
- **Present application interests:**
  - Calorimetry with fiber-based optical readout
  - Large – area scintillator – based muon counters
  - Scintillating fiber – based tracking
  - future space experiments for detection of UHECR
  - FEL studies and instrumentation
  - future large – area, ground – based x-ray telescopes
- **Action Plan:**
  - comparative studies for detailed understanding of device characteristics
  - Application tests
  - Optimization of properties as a function of application

# First year FACTOR

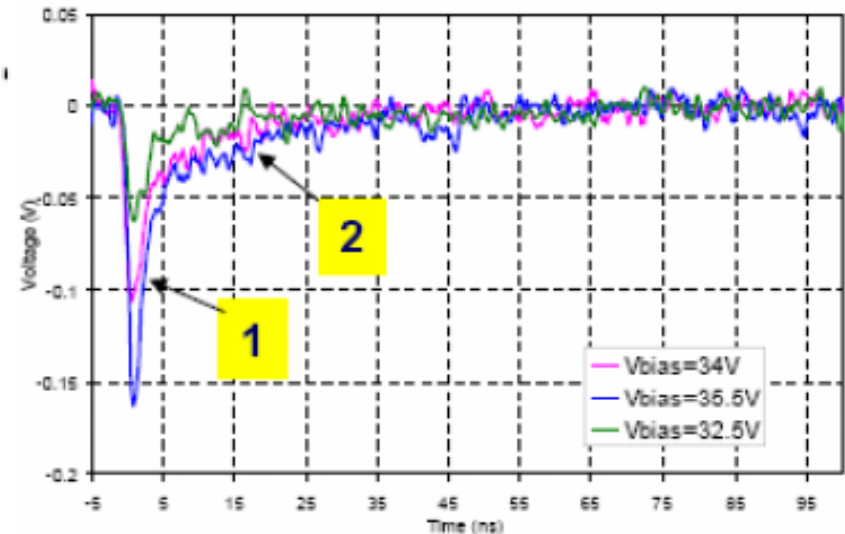
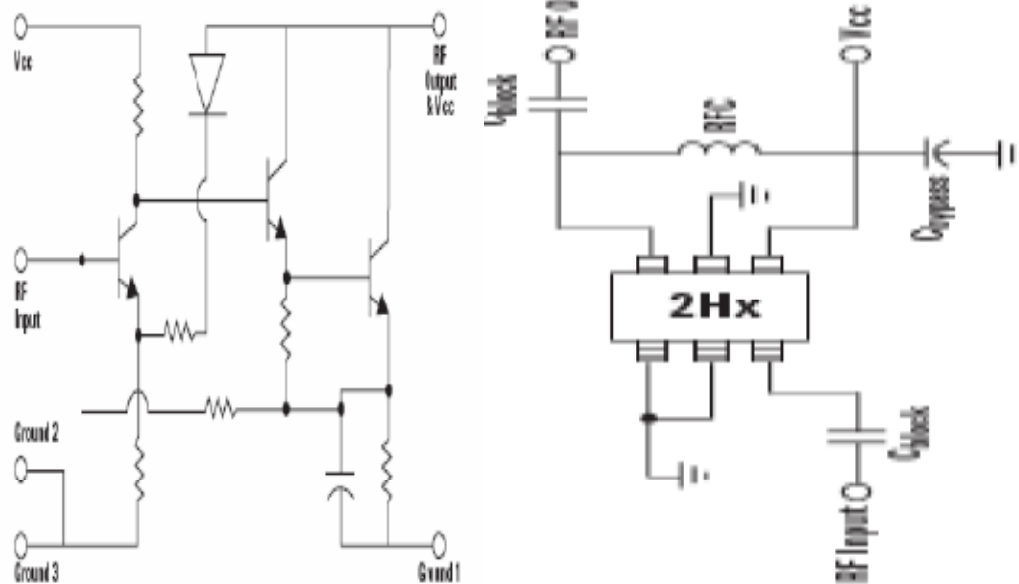
- Comparison of SiPM characteristics produced by different manufacturers;
- Measurements of SiPM characteristics as a function of T;
- Irradiation of the devices and study of radiation damage effects;
- Tests with SiPMs coupled to wls fibers for scintillator read-out.
- Energy and time resolution measurements;
- Study of optimal packaging, electronics placement, etc.
- At the moment, we are performing tests on SiPMs from 3 different sources:
- Forimtech (MRS):
  - 1 mm<sup>2</sup> in TO18 -  $\lambda_P \approx 560$  nm - 556  $\mu$ cells  $\sim 43 \times 43$   $\mu$ m<sup>2</sup>
- Photonique (MRS):
  - “GR sensitive” - 1 mm<sup>2</sup> in TO18 - 556  $\mu$ cells  $\sim 43 \times 43$   $\mu$ m<sup>2</sup>
  - “Blue sensitive” - 1 mm<sup>2</sup> in TO18 - 556  $\mu$ cells  $\sim 43 \times 43$   $\mu$ m<sup>2</sup>
  - “Blue sensitive” - 4.4 mm<sup>2</sup> on PCB - 1748  $\mu$ cells  $\sim 50 \times 50$   $\mu$ m<sup>2</sup>
  - “Blue enhanced” – 9 mm<sup>2</sup> in TO5 – 8100  $\mu$ cells  $\sim 33 \times 33$   $\mu$ m<sup>2</sup>
- IRST (polysilicon), 1 mm<sup>2</sup> -  $\lambda_P \approx 420$  nm (devices from 2nd and 3rd batch)
  - 625  $\mu$ cells, 40x40  $\mu$ m<sup>2</sup>

# Fast Amplifier

- Amplifier used for fast characterization of SiPMs:
- Agilent ABA-52563 3.5 GHz RFIC Amplifier
- (economic, compact, internally 50- $\Omega$  matched, gain  $\sim$  20 dB)



Simplified Schematic

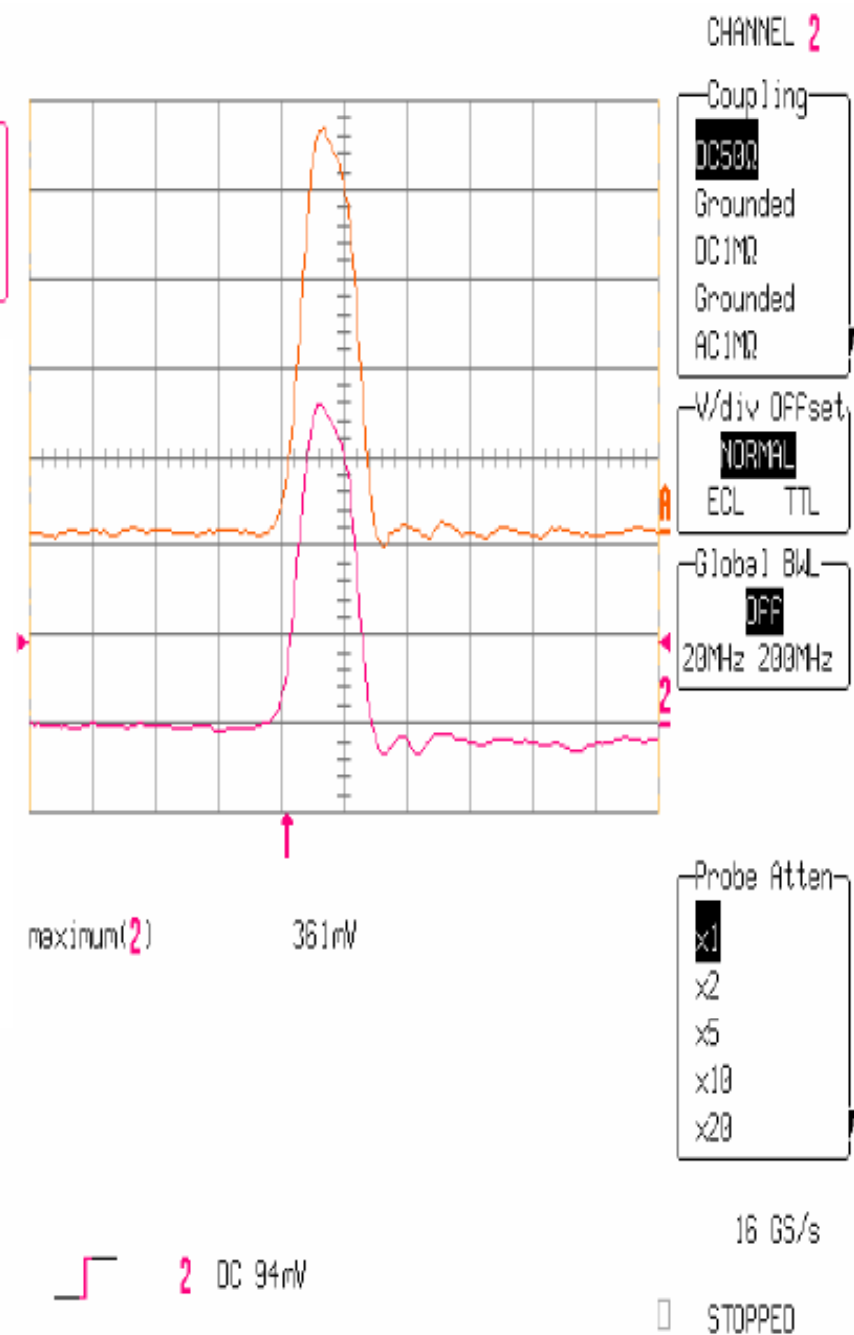


# Amplifier Characterization

- **Temperature dependence:**
- **Measurements performed with the DUT in a climatic chamber (with humidity control)**
- **The amplifier was outside the chamber, connected via a special 18 GHz ft 50  $\Omega$  cable.**
- **Timing characteristics can be studied**

16-May-07  
10:17:32

1 ns  
100 mV



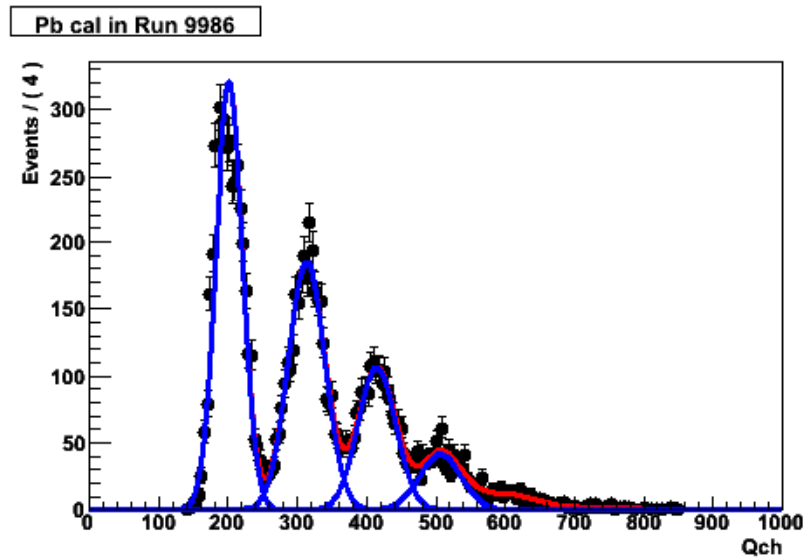
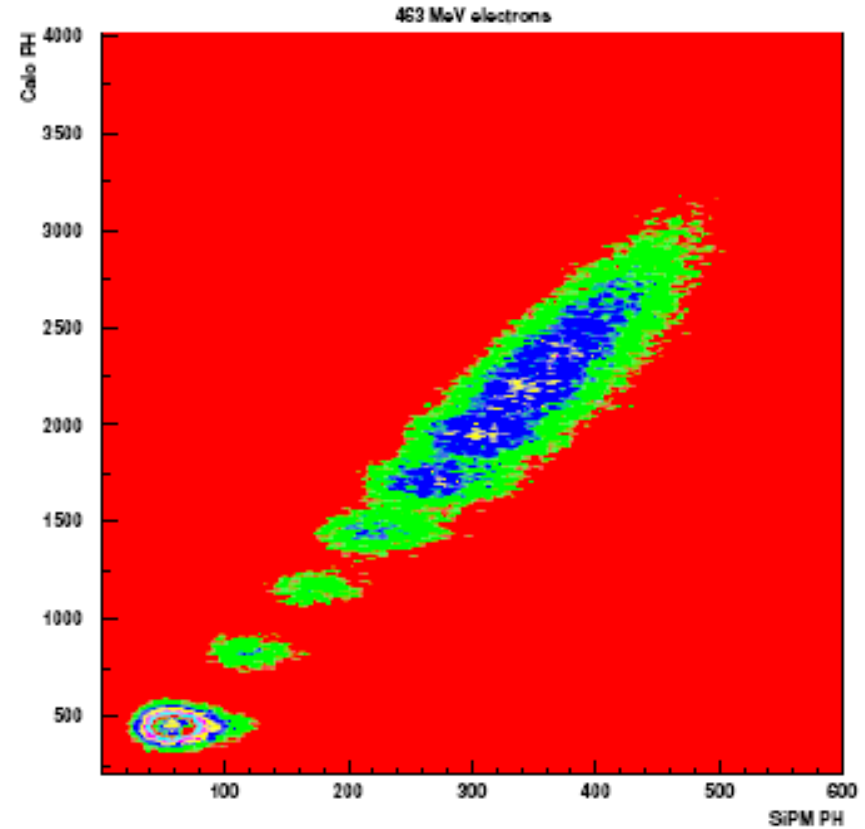
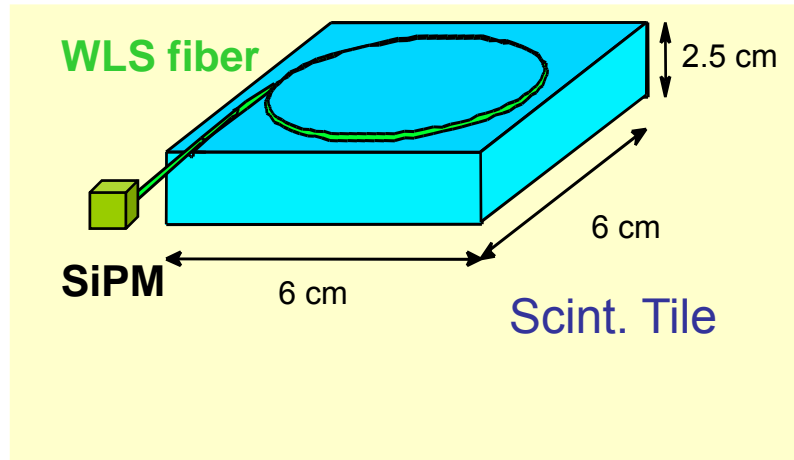
# Test Setup at INFN Lab



# Present Tasks

- **SiPM Development**
  - Comparative device characterization (ISRT, Hamamatsu, Formitech)
  - Development (in collaboration with IRST)
  - Optimization of packaging & (fast!) preamplification
- **Irradiation studies** (so far on 24 SiPM's)
  - FBK-irst, Hamamatsu Photonique, Formitech
  - X-rays @ INFN Legnaro Labs (50 – 500 krad)
  - neutrons @ IJS reactor, Ljubljana ( $\sim 4.8 \times 10^{10}$  n/cm<sup>2</sup>)
- **Application Studies**
  - Large area muon counters (FNAL)
  - Calorimetry with optical readout (FNAL/CERN/Frascati)
  - Scintillator-based fine-grained hodoscopes (CERN)
- Preliminary study of Scint. Strips viewed by IRST SiPM at the FNAL test beam (prototype of muon detector/tail catcher for ILC)

# Test at Frascati



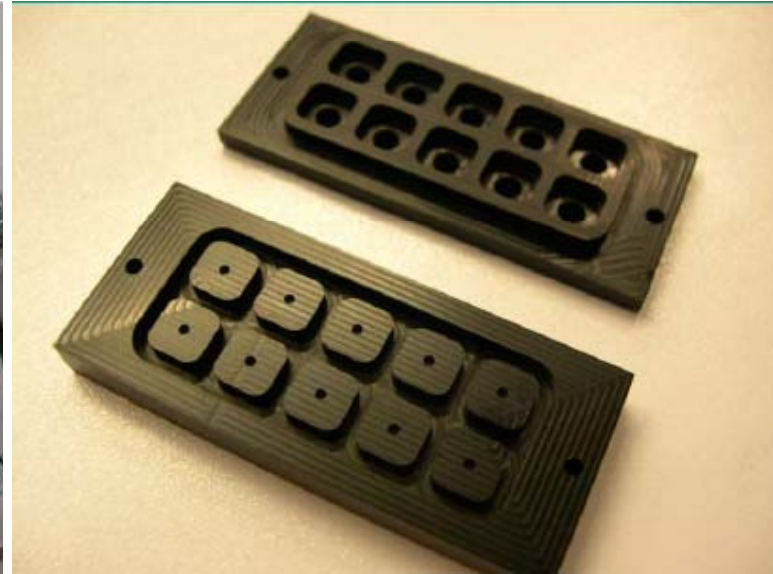
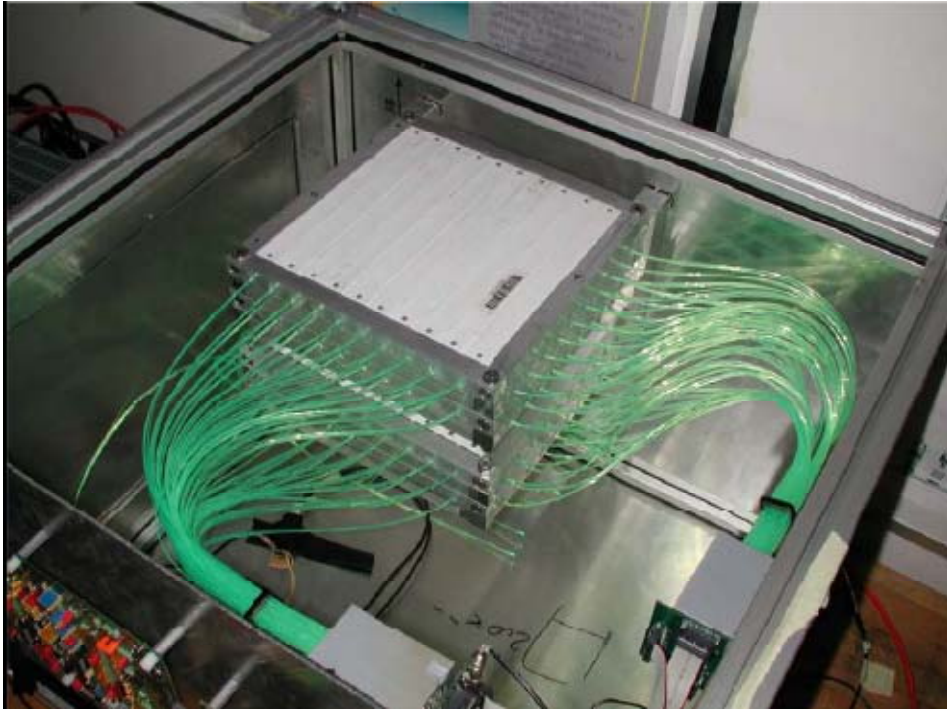
Electron beam with a Cherenkov calorimeter counting multiplicity



# Test beam at CERN

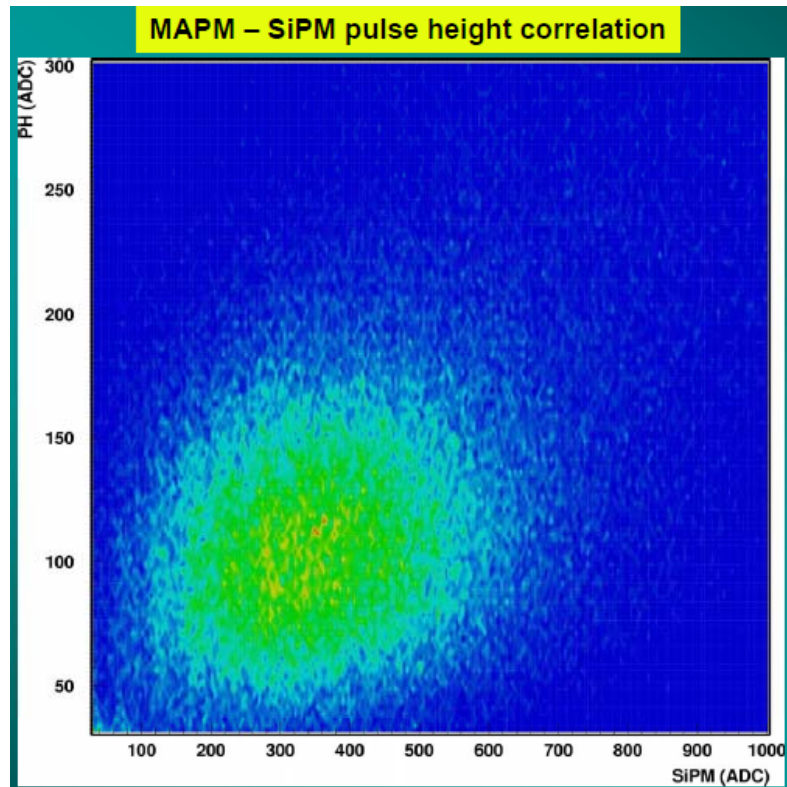
- Test beam at CERN (May/June 2008) with the MICE experiment: 8 extruded scintillator bars (1.5x1.9x19 cm<sup>3</sup>) with wls fibers, read out by SiPMs (IRST and Hamamatsu), all other bars of the MICE calorimeter read out by MAPMT.
- An ad hoc mechanical receptacle was realized to couple and align the fibers with the SiPMs and test them in a 2 GeV positron beam
- Frontend electronics: VA64TAP3.1 +LS64 by Gamma Medica-IDEAS; trigger signals sampled by an Altera with a 320 MHz clock

# Mice detector

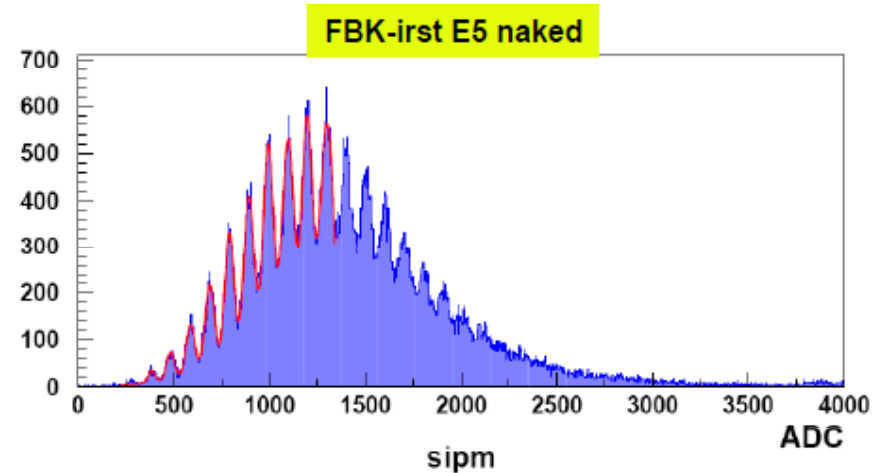


- A small fraction of the prototype fibers are readout with SiPM. The SiPM receptacle is visible to the right

# The SiPM response



Pulse-height plot of the SiPM obtained selecting good events on the MAPM side



- Correlation MAPMT vs SiPM amplitude

# Radiation studies

- Systematic campaign this year: study resistance to radiation effects of SiPMs produced by different manufacturers
  - Objective: study both surface and bulk damage in the devices
  - Types of radiation used: X-rays (up to 50 keV) and neutrons
  - Measurement strategy: I-V characterization, dark count and gain before and after irradiations, annealing studies
  - 24 devices from FBK-irst, Photonique (CPTA) and Hamamatsu irradiated so far; further irradiations are foreseen in the next weeks
- **X-rays: INFN National Laboratories of Legnaro (LNL), X-ray tube (W target), Vmax = 50 kV, dose rate measured with calibrated Si p-i-n diodes**
- **Neutrons: Nuclear Reactor of the Institute Josef Stefan of Ljubljana (Slo), max power ~ 250 kW, very high fluence achievable**

**X-rays @ INFN Legnaro Labs (50, 100 and 150 krad);**

**X-rays @ INFN Legnaro Labs (300 and 500 krad);**

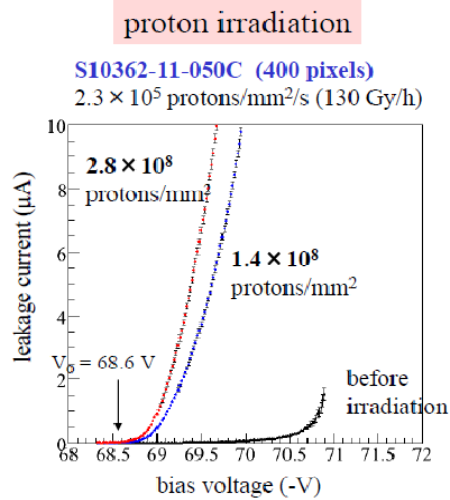
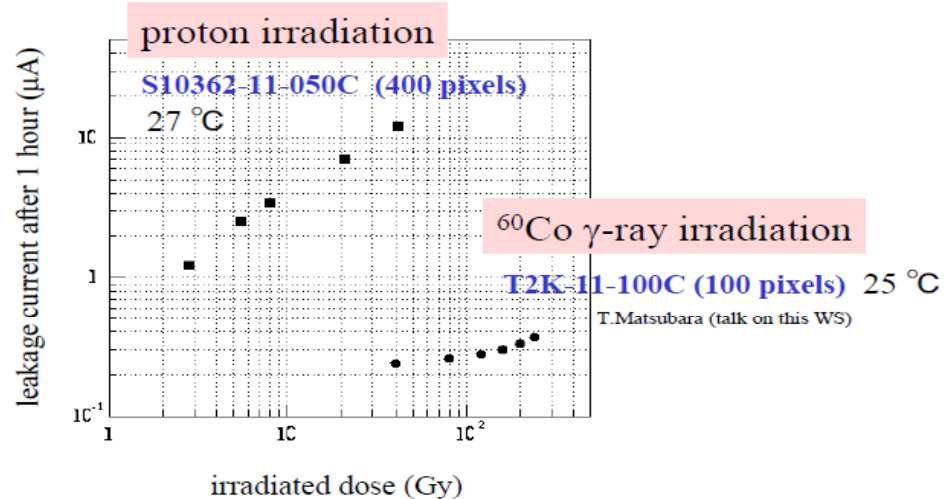
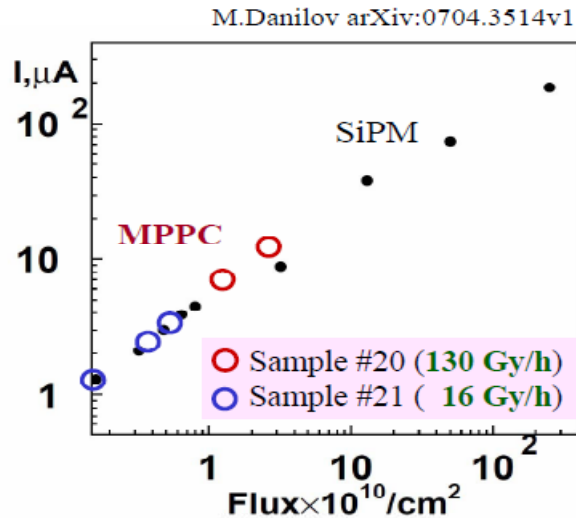
**neutrons @ IJS reactor, Ljubljana (fluence ~  $4.8 \times 10^{10}$  n/cm<sup>2</sup>);**

## Irradiation studies (so far on 24 SiPM's)

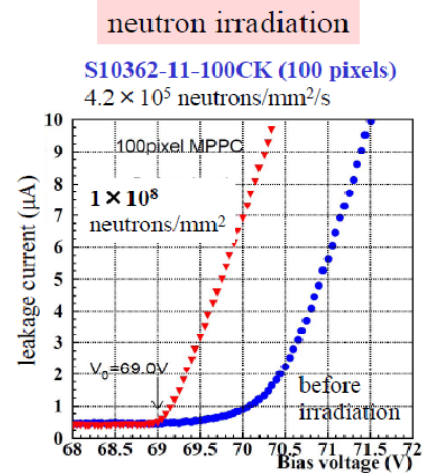
- X-rays @ INFN Legnaro Labs (50 – 500 krad)
- neutrons @ IJS reactor, Ljubljana ( $\sim 4.8 \times 10^{10}$  n/cm<sup>2</sup>)
- (spectrum ?)
- Very preliminarily:
  - With 300 krad X-rays, HPK DC increase by 20 – 25
  - FBK by 4 - 5
  - With 500 krad, HPK by 36-40, FBK by 6 - 8
  - With  $4.8 \times 10^{10}$  n/cm<sup>2</sup>, HPK DC increase by 45-60, FBK by 15 - 20 .

(See next page)

# Other measurements and estimates



$$I_{\text{leak}} @ (V_{\text{op}}, 1.4 \times 10^8 \text{ p}/\text{mm}^2) = 6.7 \mu\text{A}$$



$$I_{\text{leak}} @ (V_{\text{op}}, 1.0 \times 10^8 \text{ n}/\text{mm}^2) = 8.5 \mu\text{A}$$

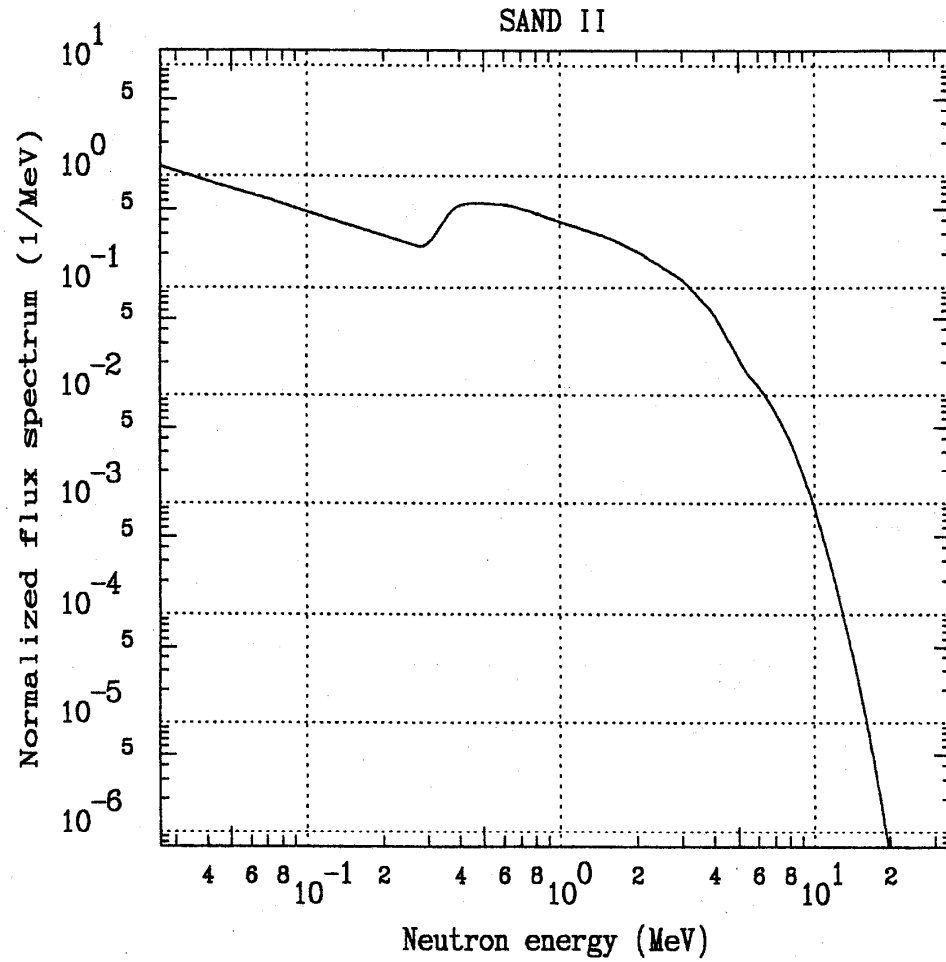
See:

T. Matsumura (June 29, 2007)  
International Workshop on new  
photon-detectors (PD07)  
(Kobe University)

Neutron  $\approx$  Proton

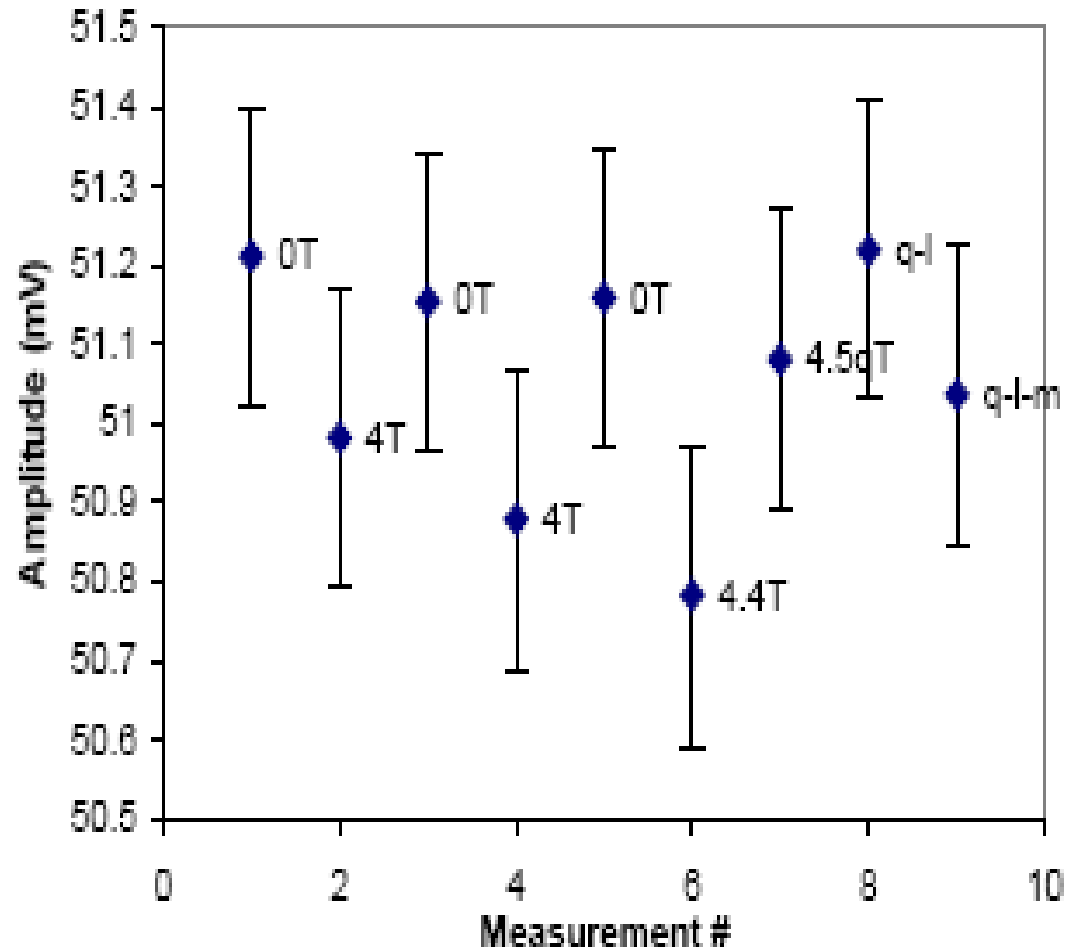
Proton  $\approx$  100 x X-ray

# Triga 3 reactor JSL



# Magnetic field resistance

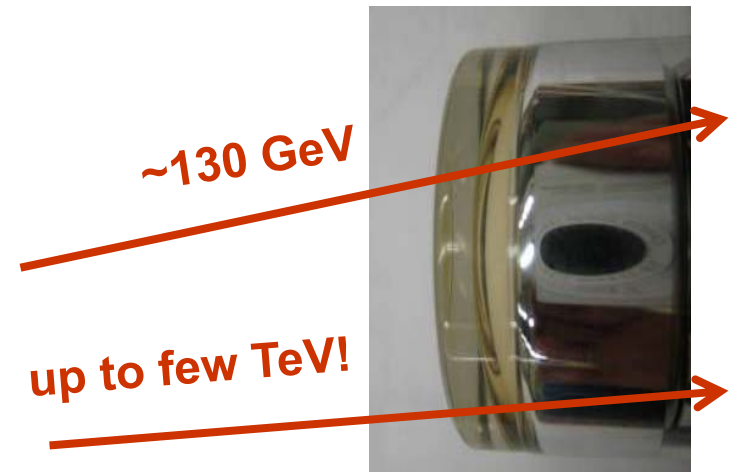
- “Investigation of a Solid-state Photodetector”, NIM A 545:727-737 (2005).
- “Effects of a strong magnetic field on LED, extruded scintillator and MRS photodiode”, NIM A553: 438-447 (2005)
- (Vishnu V. Zutshi)



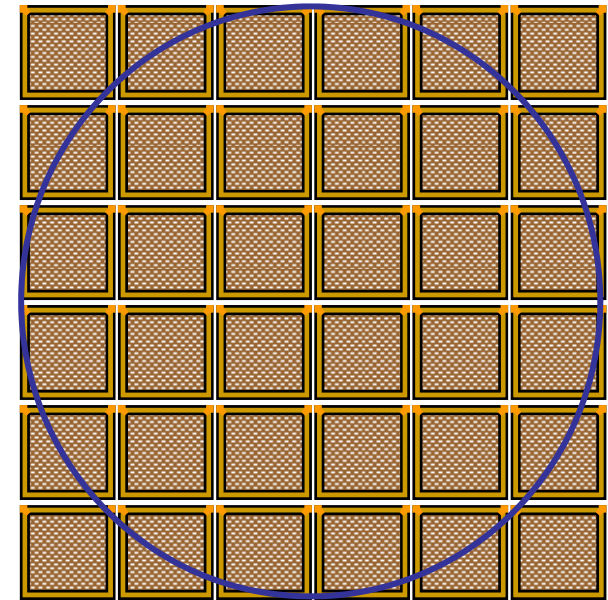


# SiPM for HF?

- PMT fake signals in HF: show-stopper?
- SiPM useful but:
- Radiation hard?
- Small dimensions?
- Dinamic range?
- Consider matrix of  $4 \times 4$  mm<sup>2</sup> FBK SiPM
  - To cover 2.4 cm diameter PMT window



## *SiPM matrix...*



...if 1 SiPM costs  $\leq 10\$$  ...  
... not out of question?

